

# **TB 2022: Geant4 simulations & Data Comparison**

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# TB 2022 Simulations Step by Step

- geometry

- complete implementation of all type of sensors – Anton1, Yan1, BeamCal, C72, C74, C75
- re-numbered the pads to correspond to channels from real sensors
- macro with commands for easily geometry change

- physics list

- check results with another physics list suggested by Geant4 – QGSP\_BERT, QGSP\_BIC and those with electromagnetic options (\_EMV, \_EMX, EMZ..)
- start / stop hadronic processes to investigate their influence on results
- implement specific physics list - one developed by Alina a few years ago for FCal

- analysis

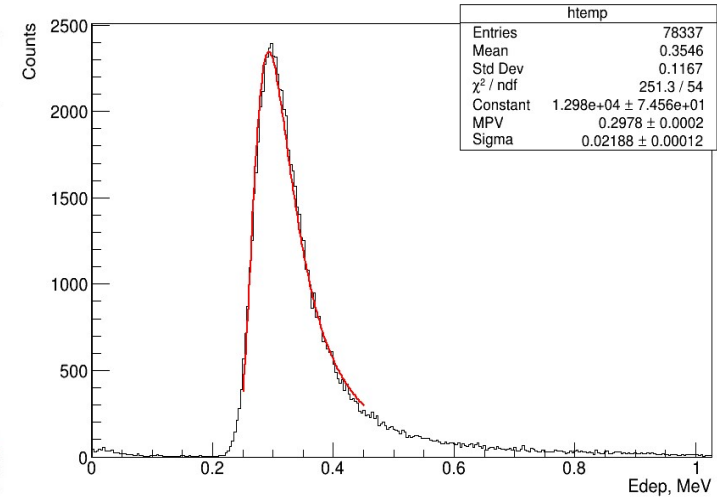
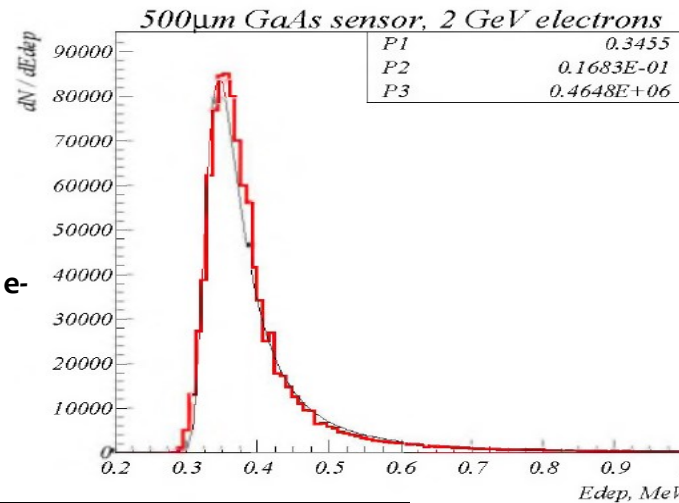
- evaluate each pad energy deposition
- fit the energy deposition histograms to get the MPV
- evaluate MPV for different setup configurations
- compare simulation results with data from test beam
- find the longitudinal shower distribution for different configurations (e.g. 1 to 15 W plates in front of sensor)

## ■ GaAs sensor – Anton1

# Simulations: Number of e-h pairs created

### Olga Novgorodova's Thesis:

- Energy deposition in GaAs sensor
- 500  $\mu\text{m}$  thickness
- $^{90}\text{Sr}$ , and 2, 4 & 4.5 GeV mono-energetic e-
- Triggered by 2 / 3 scintillators



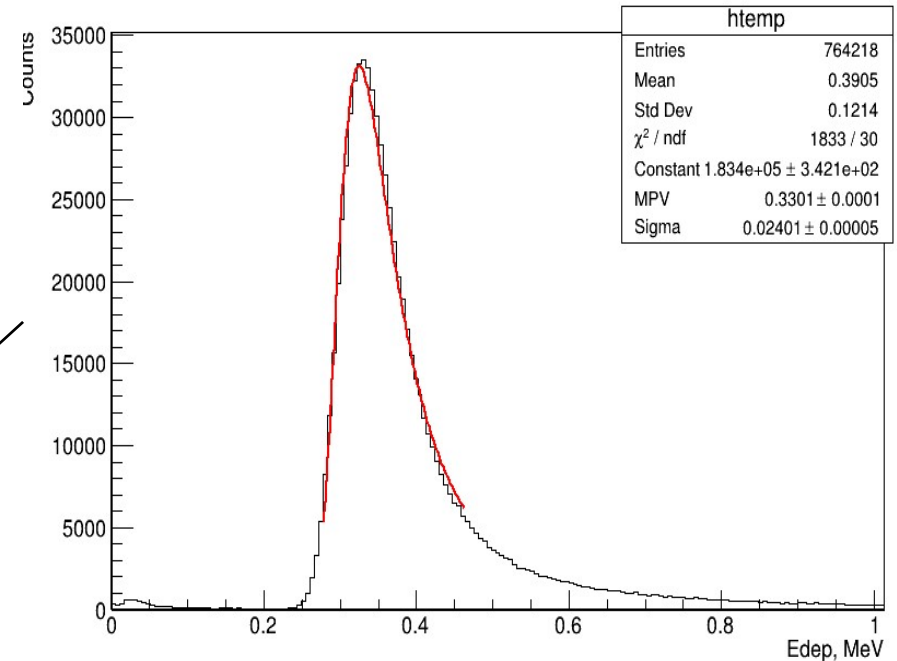
Setup	Dep. En. (MeV)	e-h pairs / $\mu\text{m}$	Dep. En. (MeV)	e-h pairs / $\mu\text{m}$
$^{90}\text{Sr}$	0.3512	163.4	0.3555	165.34
2 GeV	0.3455	160.7	0.3546	164.93
4 GeV	0.3513	163.4	0.3558	165.48
4.5 GeV	0.3526	164.0	0.3544	164.84

### Why differences?

- which are the characteristics of triggers: dimensions, positions, etc.
- landau fit parameters

- Thickness: 550  $\mu\text{m}$
- $E_e = 5 \text{ GeV}$
- $E_i = 4.3 \text{ eV}$

Dep. en. 0.3908 MeV  
pairs /  $\mu\text{m}$  165.12 e-h

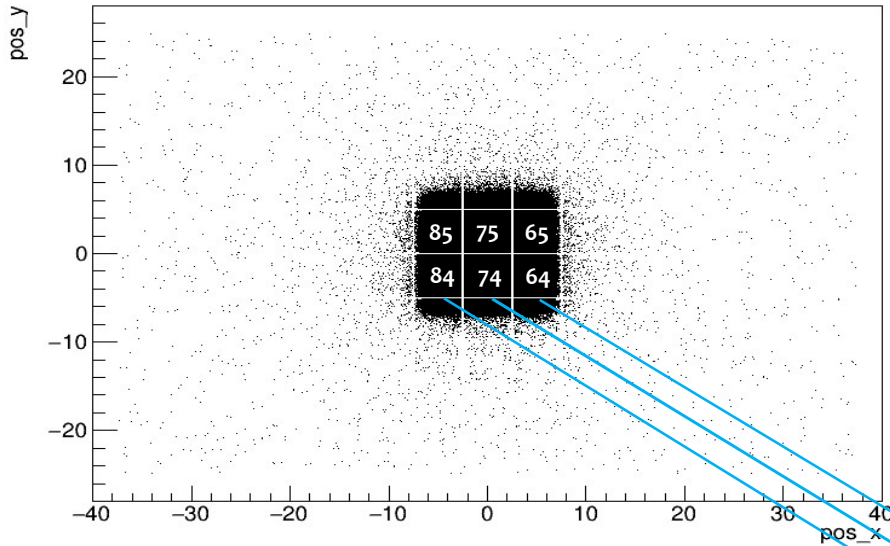


- Physics list used: FTFP\_BERT\_EMZ

## ■ GaAs sensor – Anton1

# Simulations: Hit map

pos\_y:pos\_x



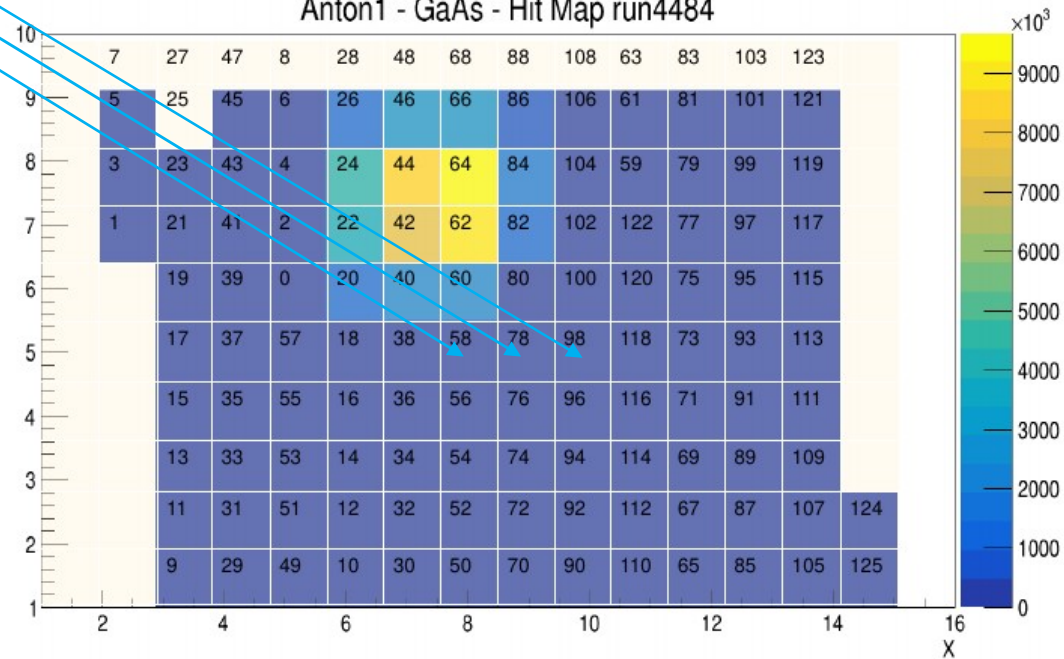
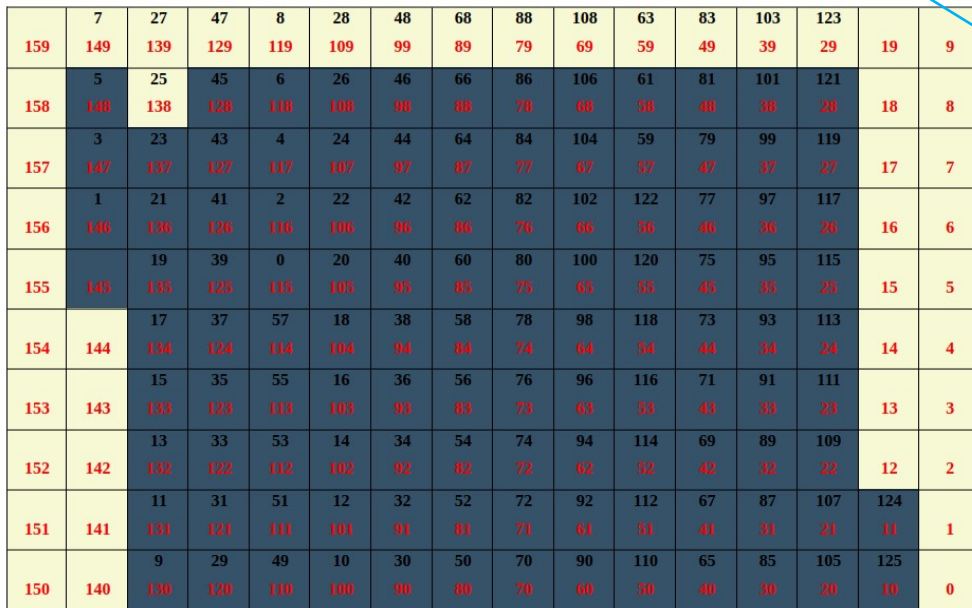
## Simulation setup

- Primary particle: electron
- Primary particle energy: 5GeV
- Source type:
  - squared,
  - 12 mm x 12 mm
- Number of simulated events: 1 000 000

## Hits registered position

- Centered on pads 64, 65, 74, 75 , 84, 85
- **Converted to channel number from sensor**

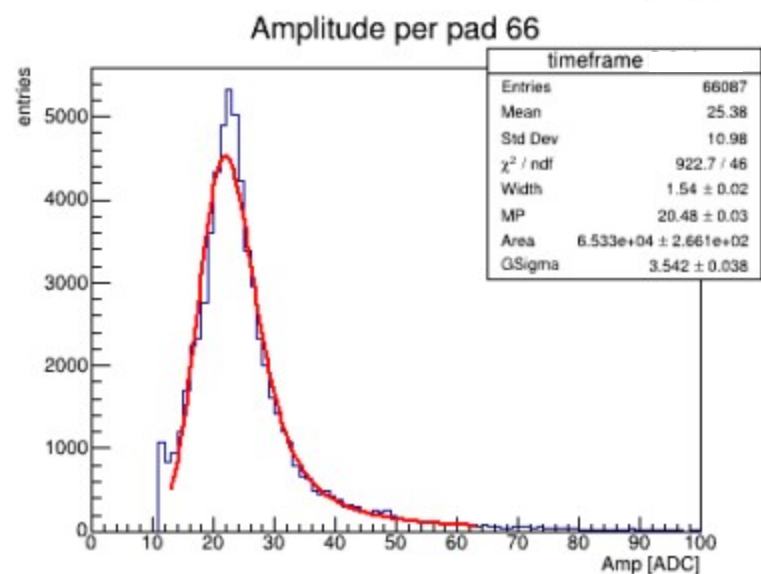
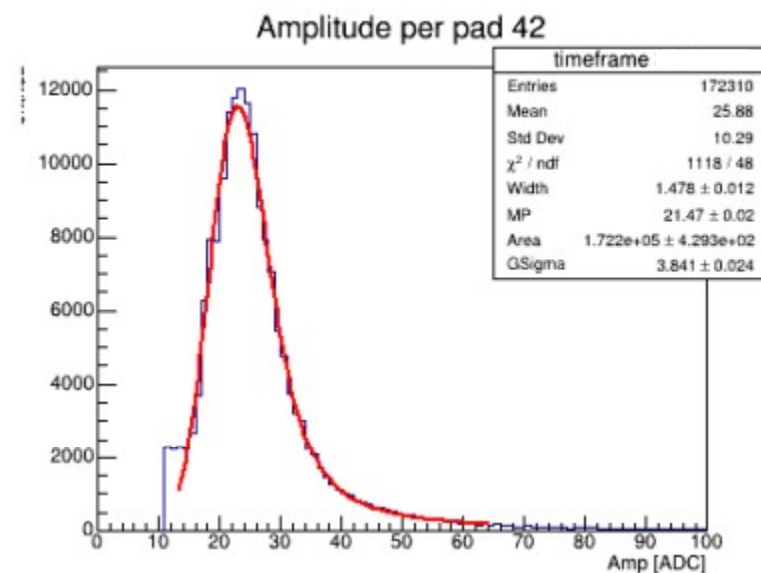
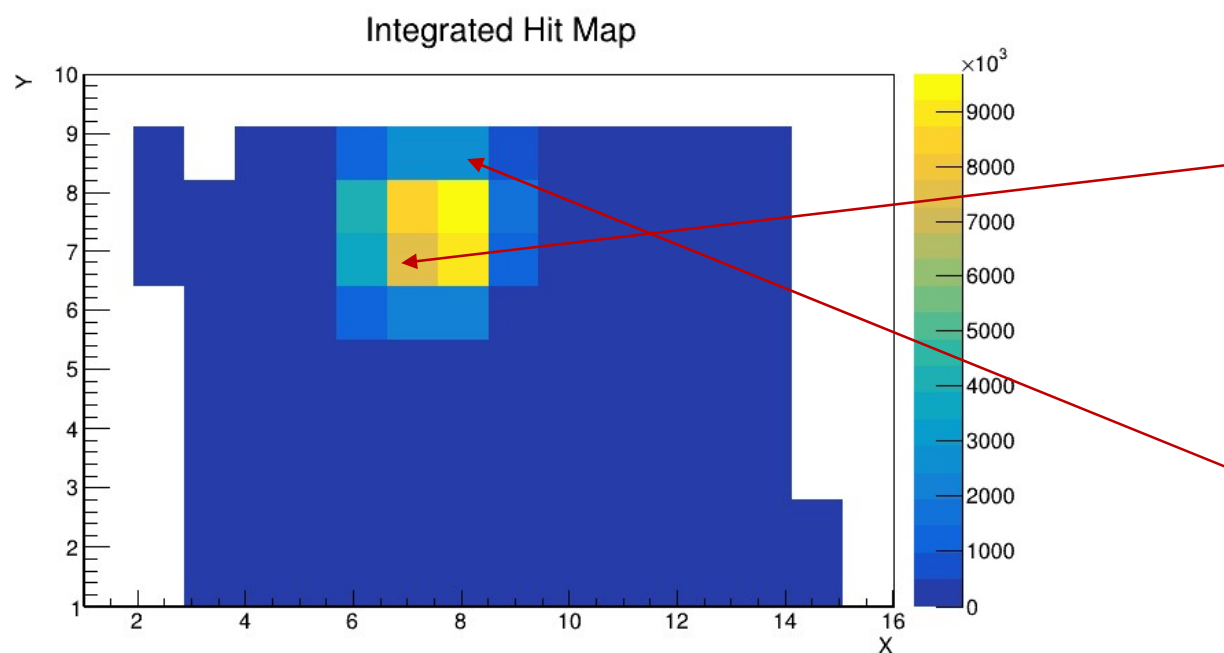
Anton1 - GaAs - Hit Map run4484



## ■ GaAs sensor – Anton1

## 2022 TestBeam: MeV to ADC

- Channel by channel gain calibration can be done by looking on the response of sensor directly exposed on MIPs deposition in Si sensor
- for each pad a (Landau & Gauss) function was fitted to energy spectrum



### Analysis conditions

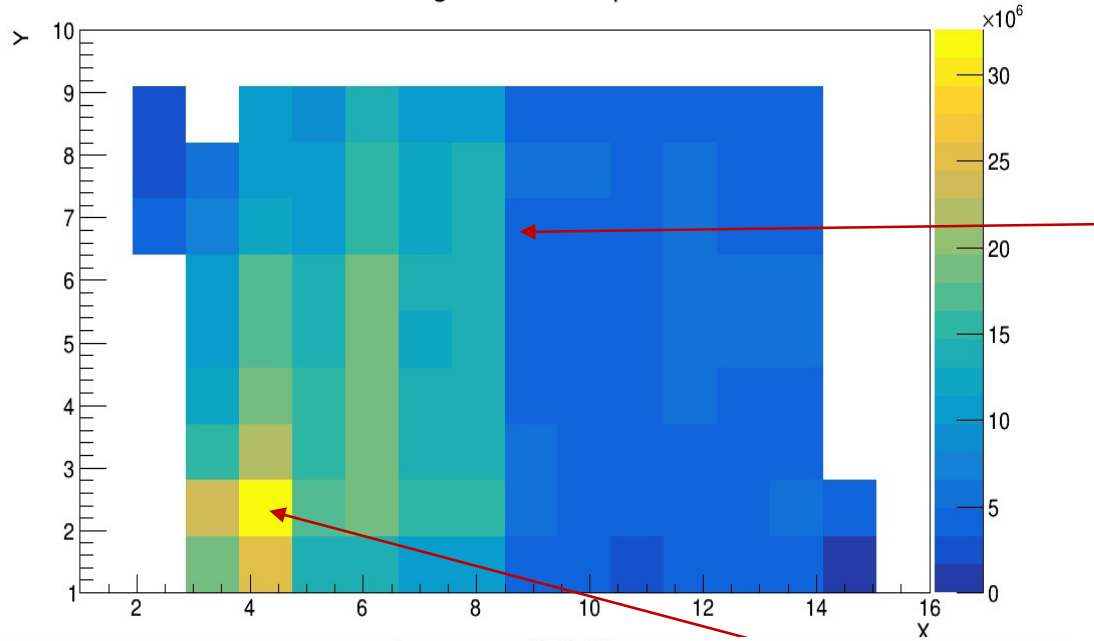
#### Data from run4484 – Anton1 sensor

- Beam on pads 42, 44, 62, 64
- Converted to channel number from sensor
- Kept all timeplanes
- Cut on amplitude < 900
- dead channels masked
- langaus fitted in range [12-64] ADC

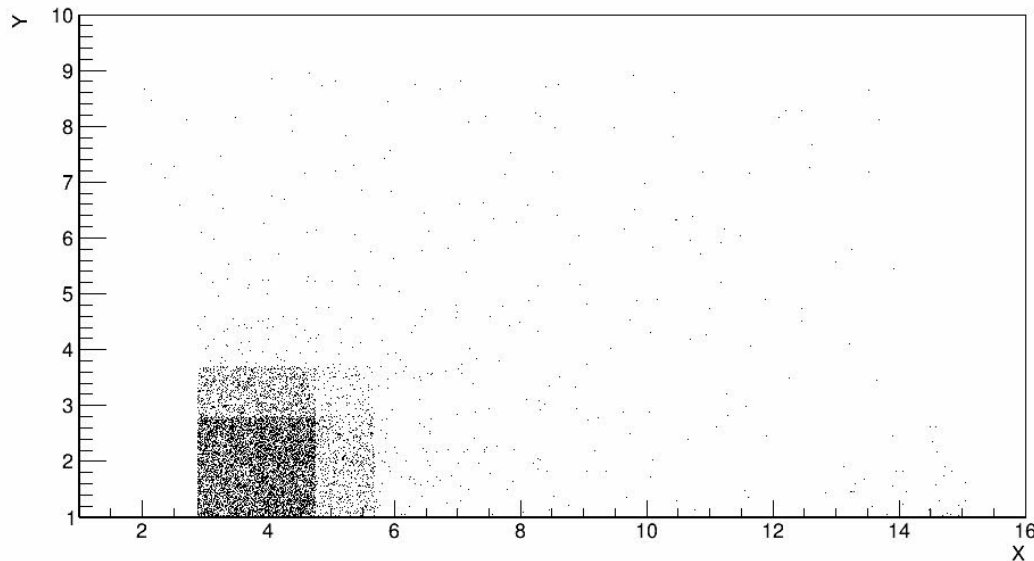
## ■ GaAs sensor – Anton1

# 2022 TestBeam: MeV to ADC

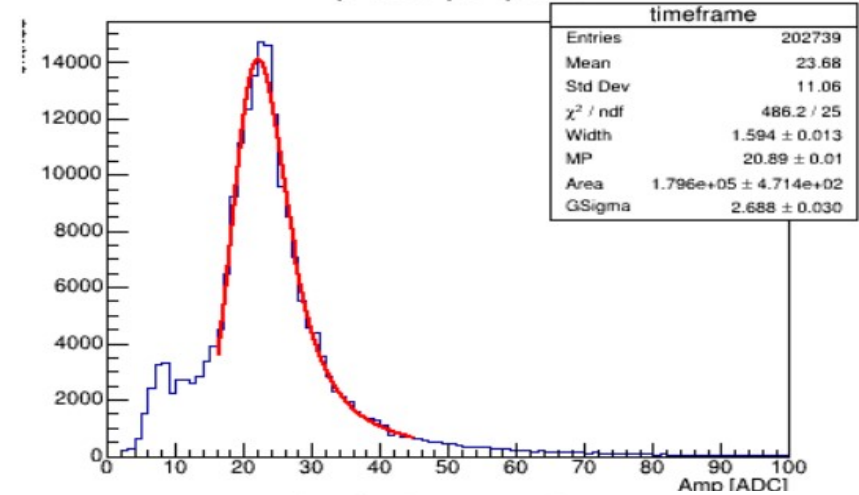
Integrated Hit Map



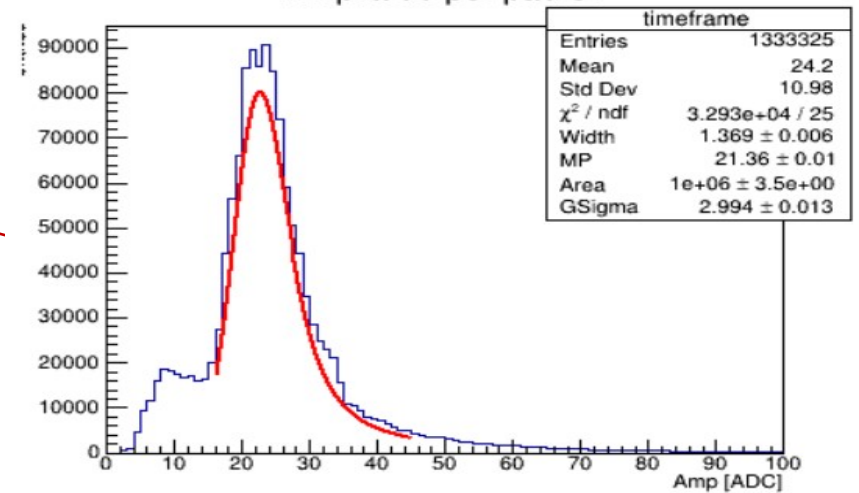
Integrated Hit Map



Amplitude per pad 82



Amplitude per pad 31



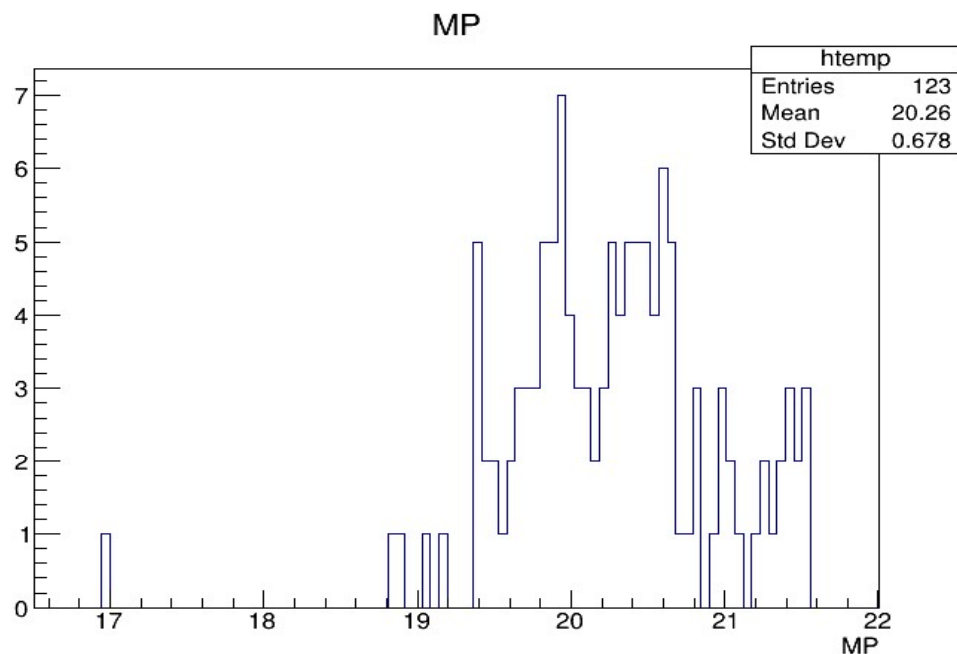
- merged all data from run4459 till run4491
- runs with Debug-data-ON or test runs not taken into account
- beam energy: 5 GeV
- greater number of runs and events for the left side of sensor



## ■ GaAs sensor – Anton1

# 2022 TestBeam: MeV to ADC

- 2 cases investigated: [run 4484] & [run 4459 – run 4491]
- fit with (Landau & Gauss) function all channels in [12-64] ADC range

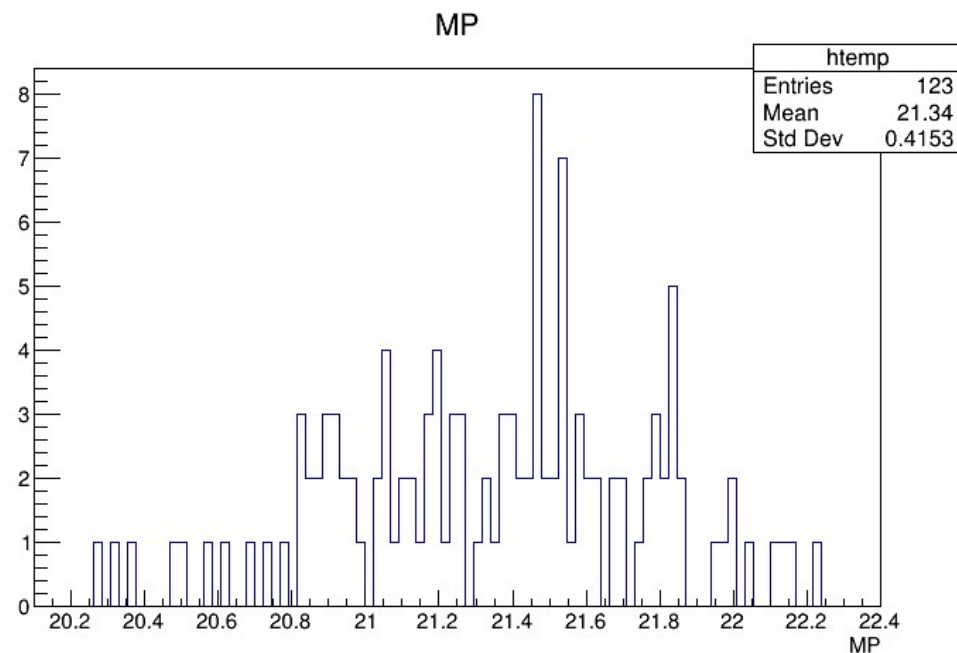


### Data from run4484

- Beam on pads 42, 44, 62, 64
- **$MPV = 20.26 \pm 0.68$  [ADC]**

### Data from merged runs

- **$MPV = 21.34 \pm 0.42$  [ADC]**

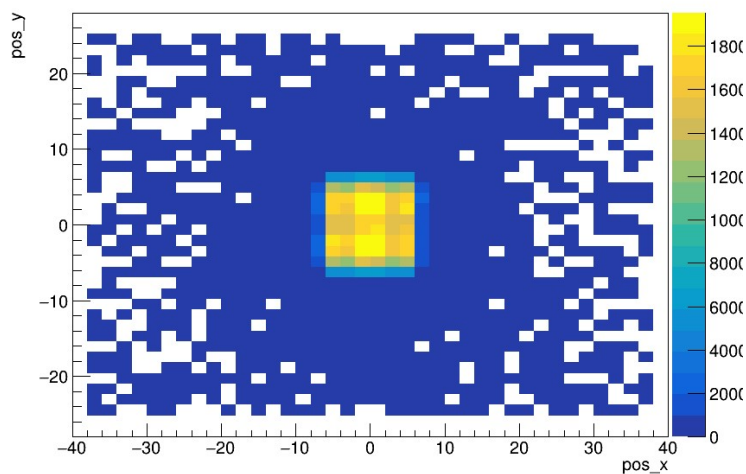


## ■ GaAs sensor – Anton1

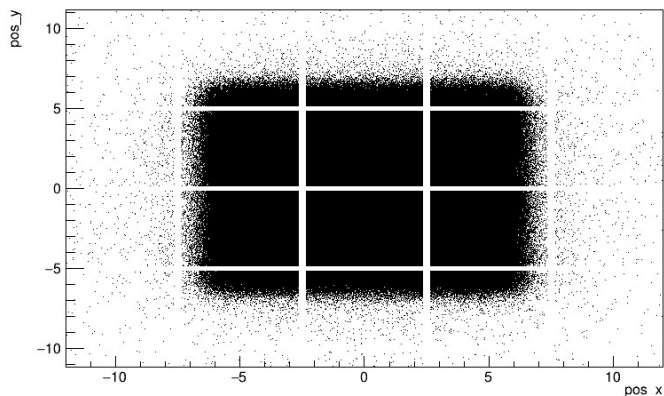
### Simulation setup

- $e^-$  with 5GeV
- centered on pads 64, 65, 74, 75, 84, 85
- source type: squared, 12 mm x 12 mm
- Number of simulated events: 1 000 000
- **Similar with run4484**

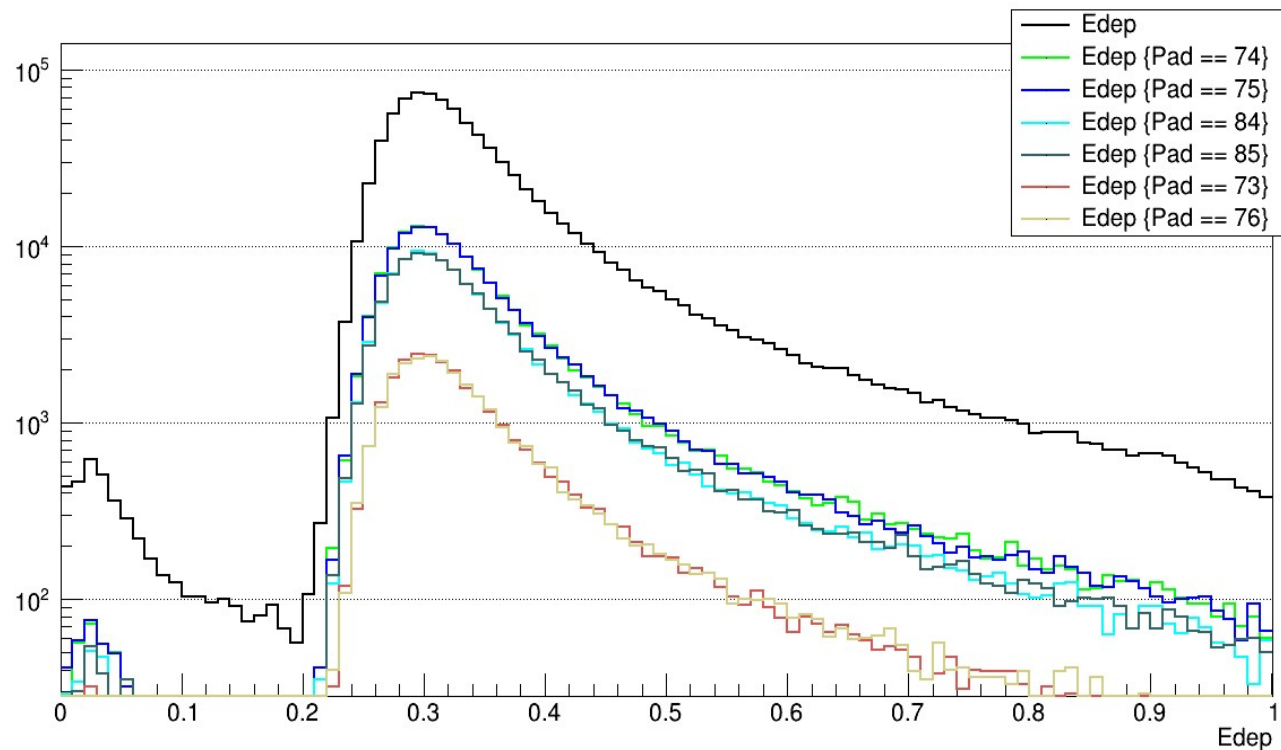
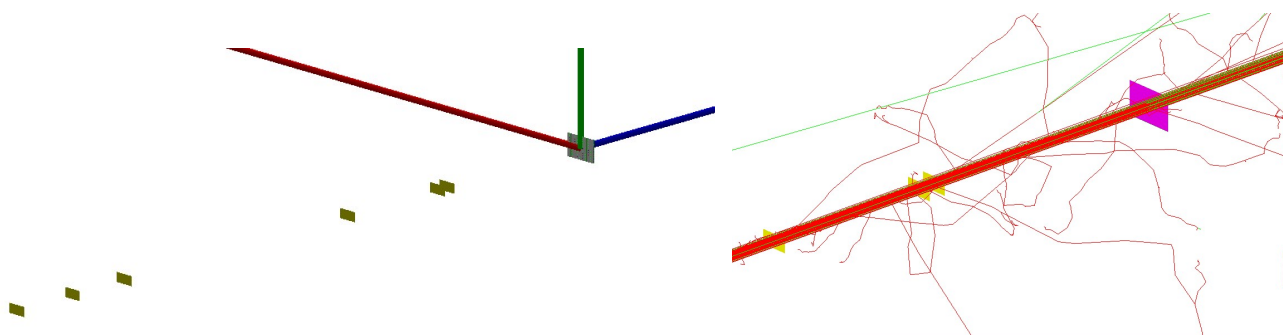
pos\_y:pos\_x



pos\_y:pos\_x



## TB 2022: Simulations





## ■ GaAs sensor – Anton1

from data, run4484

- $1 \text{ MIP} = 20.26 \pm 0.68 \text{ [ADC]}$

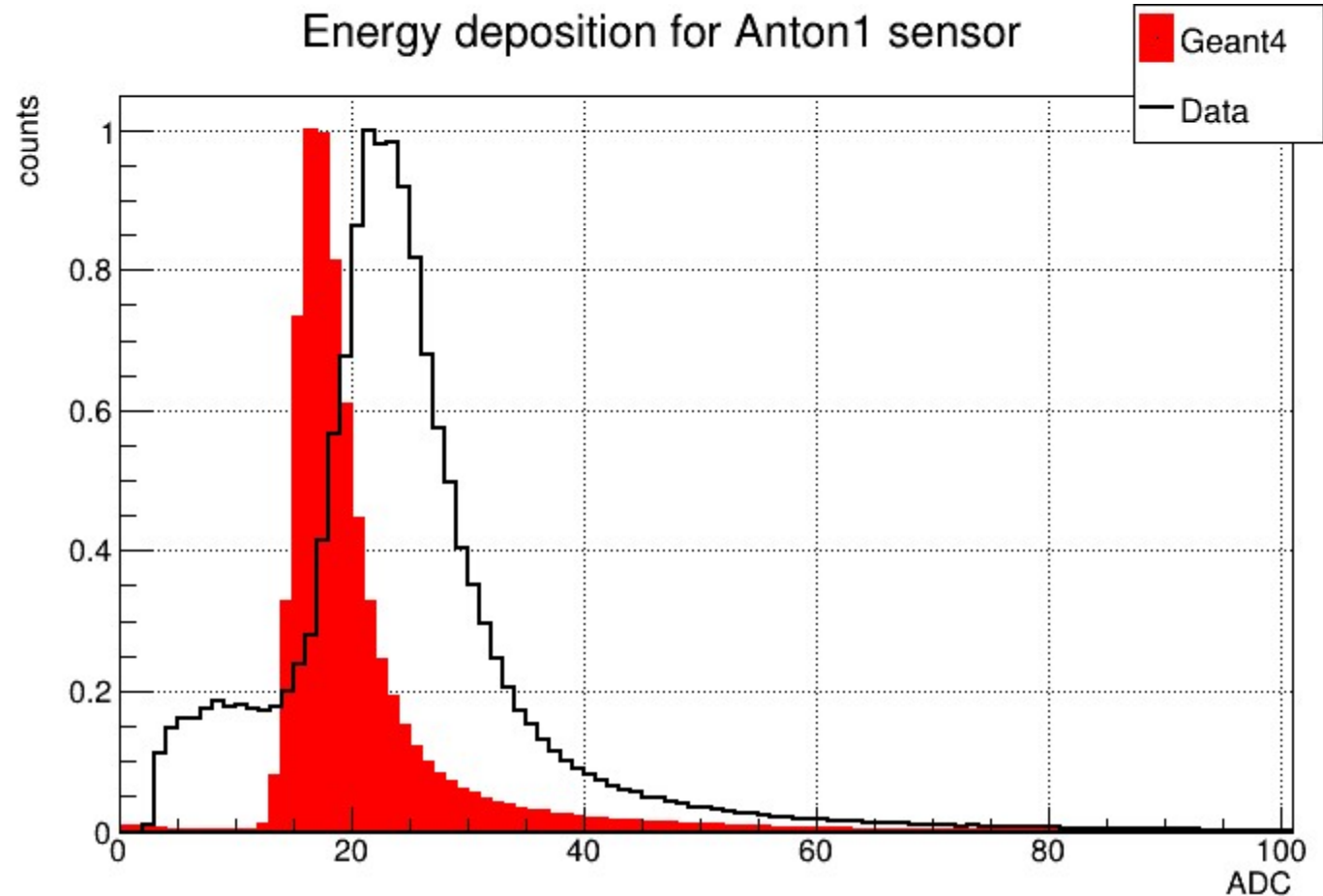
from simulations

- $1 \text{ MIP} = 0.3569 \pm 0.12 \text{ MeV}$

## TB 2022: Simulations vs Data

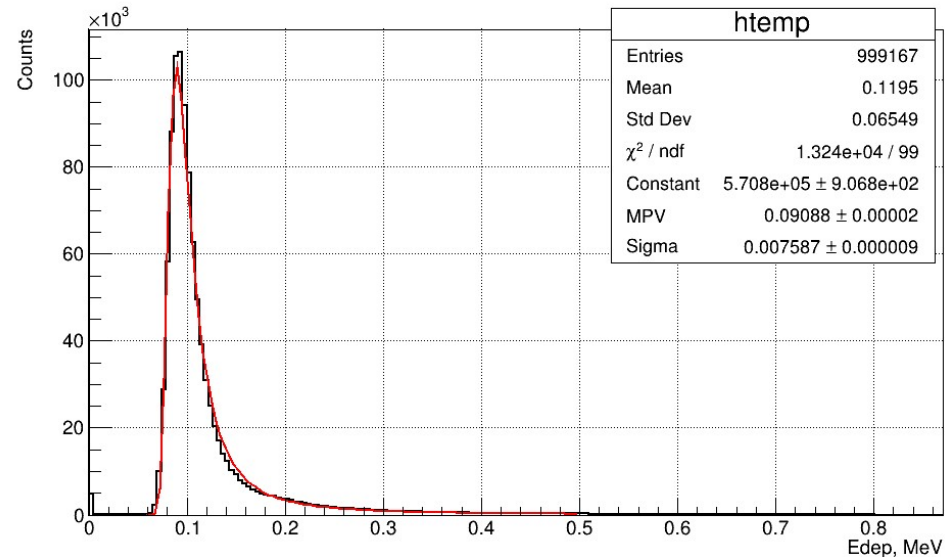
goal: compare simulations with data

- $1 \text{ MeV} = 56.77 \text{ ADC}$



## ■ Si sensor

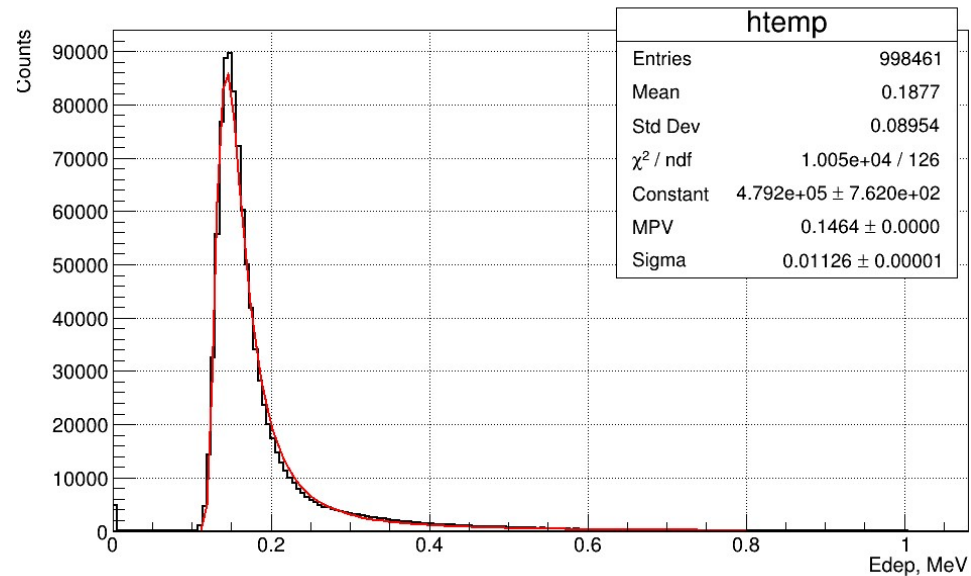
- Energy deposition in Si sensor
  - 320  $\mu\text{m}$  thickness
  - 5 GeV mono-energetic e-
  - triggered by 3 scintillators



- Thickness: 320  $\mu\text{m}$
- $E_{e^-} = 5 \text{ GeV}$
- $E_i = 3.62 \text{ eV}$

78.45 e-h pairs per  $\mu\text{m}$

- Energy deposition in Si sensor
  - 500  $\mu\text{m}$  thickness
  - 3 GeV mono-energetic e-
  - triggered by 3 scintillators



- Thickness: 500  $\mu\text{m}$
- $E_{e^-} = 3 \text{ GeV}$
- $E_i = 3.62 \text{ eV}$

80.88 e-h pairs per  $\mu\text{m}$

- Physics list used: QGSP\_BERT\_EMZ

## ■ Si sensor – C75

# 2022 TestBeam: MeV to ADC

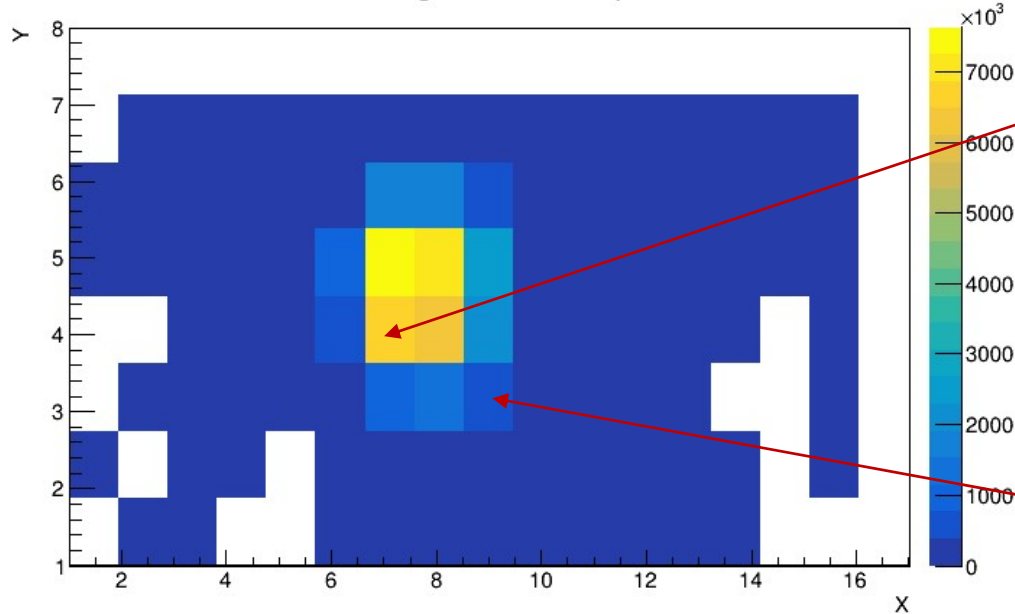
### Data from run4436 – C75 sensor

- Beam on pads 49, 51, 59, 61

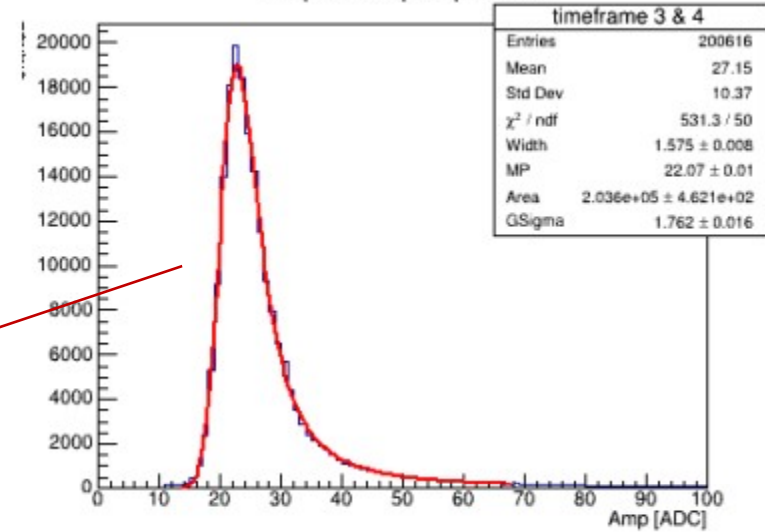
### Analysis conditions

- Kept all timeplanes
- Cut on amplitude < 900
- dead channels masked
- langaus fitted in range [12-64] ADC

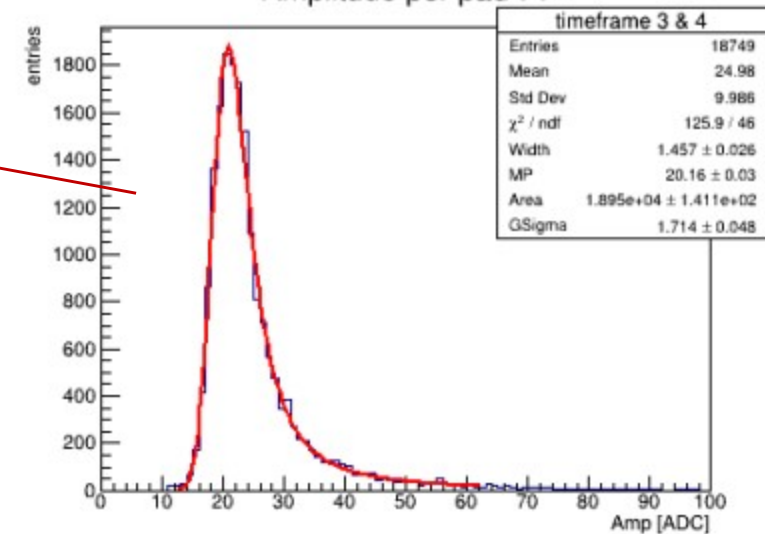
Integrated Hit Map



Amplitude per pad 49



Amplitude per pad 71

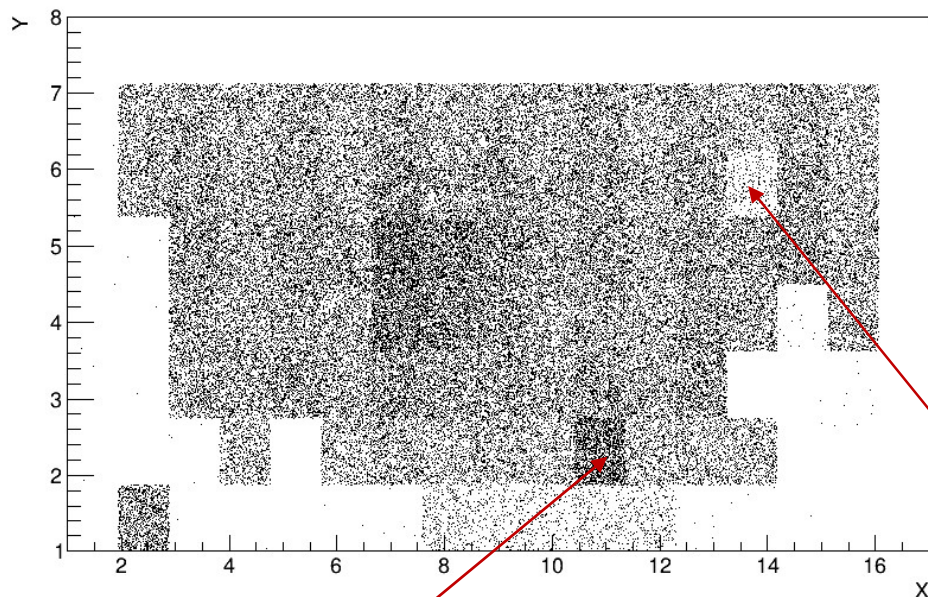


- a lot of channels are dead or unresponsive
- for each pad a (Landau & Gauss) function was fitted to energy spectrum
- The analysis showed very small deviations from channel to channel

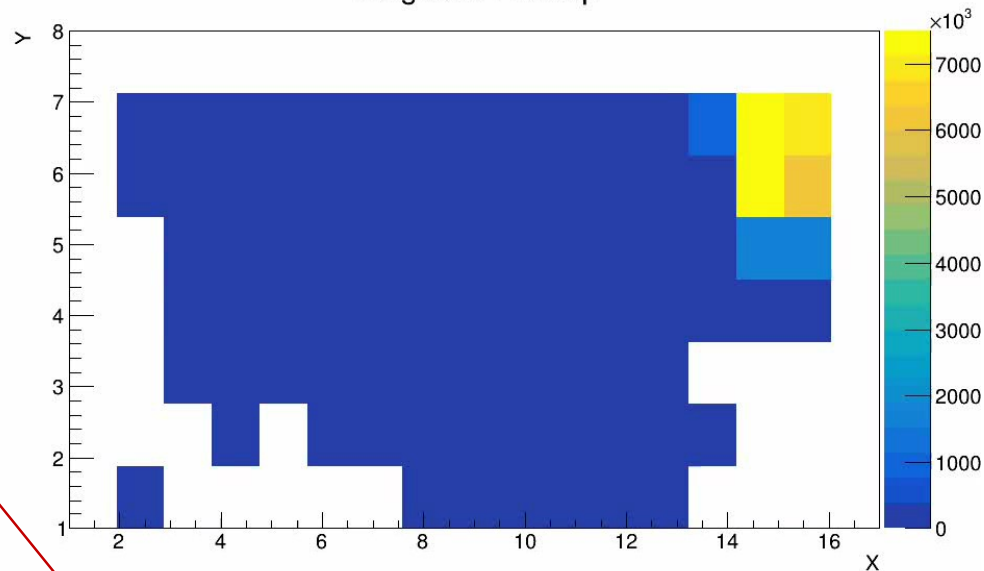
## ■ Si sensor – C75

# 2022 TestBeam: MeV to ADC

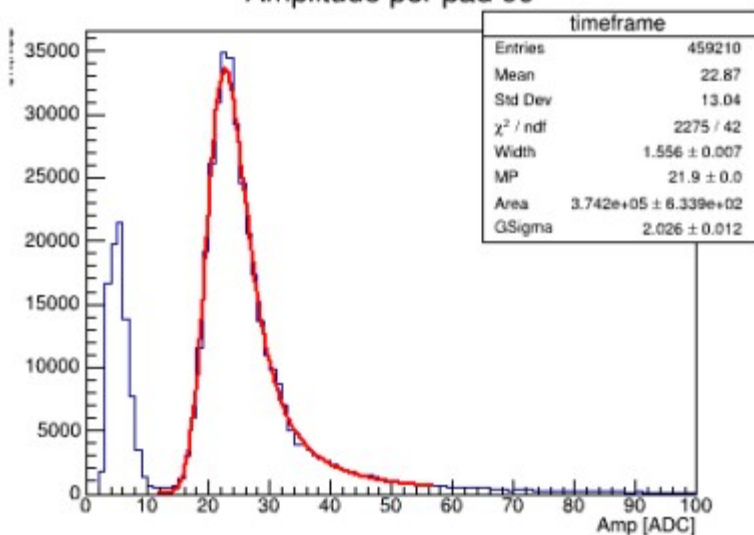
Integrated Hit Map



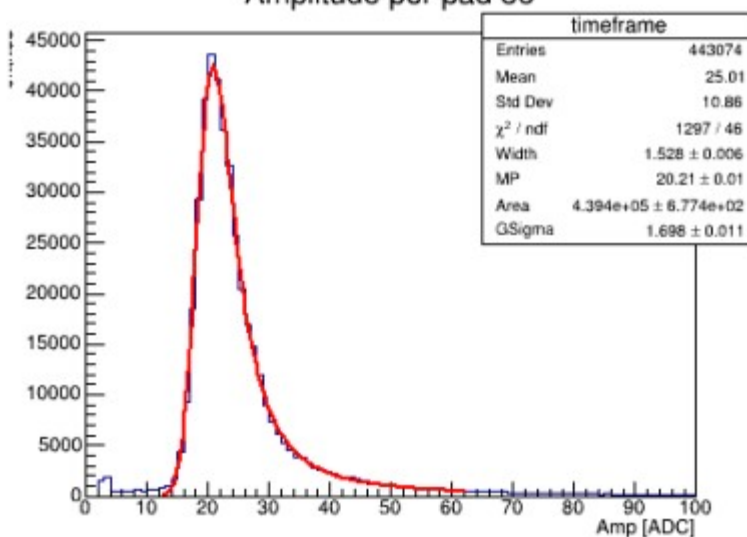
Integrated Hit Map



Amplitude per pad 99



Amplitude per pad 86



■ merged all data from run4422 till run4447

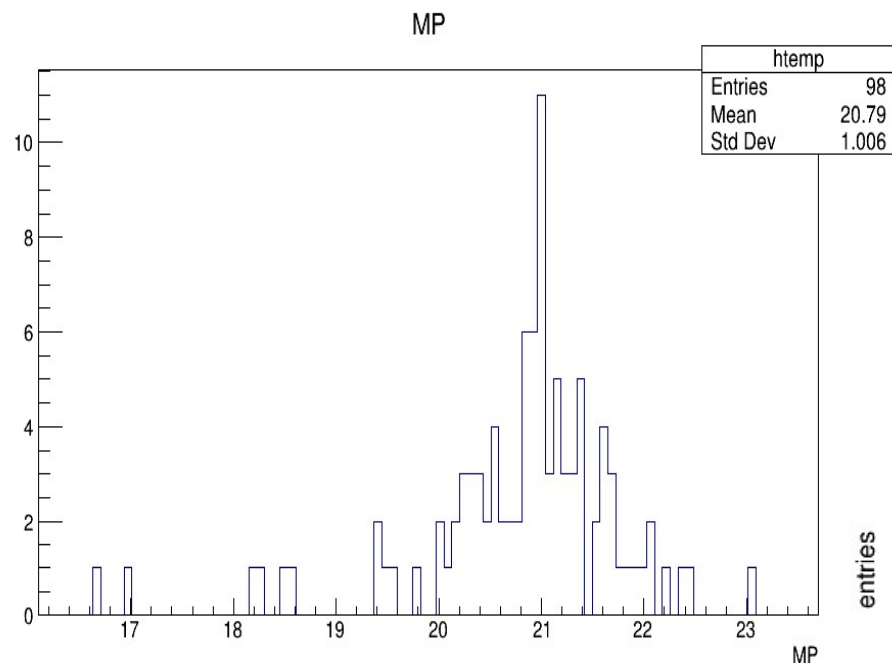
■ runs with Debug-data-ON or crashed runs not taken into account

■ beam energy: 5 GeV

■ many dead or unresponsive pads

## ■ Si sensor – C75

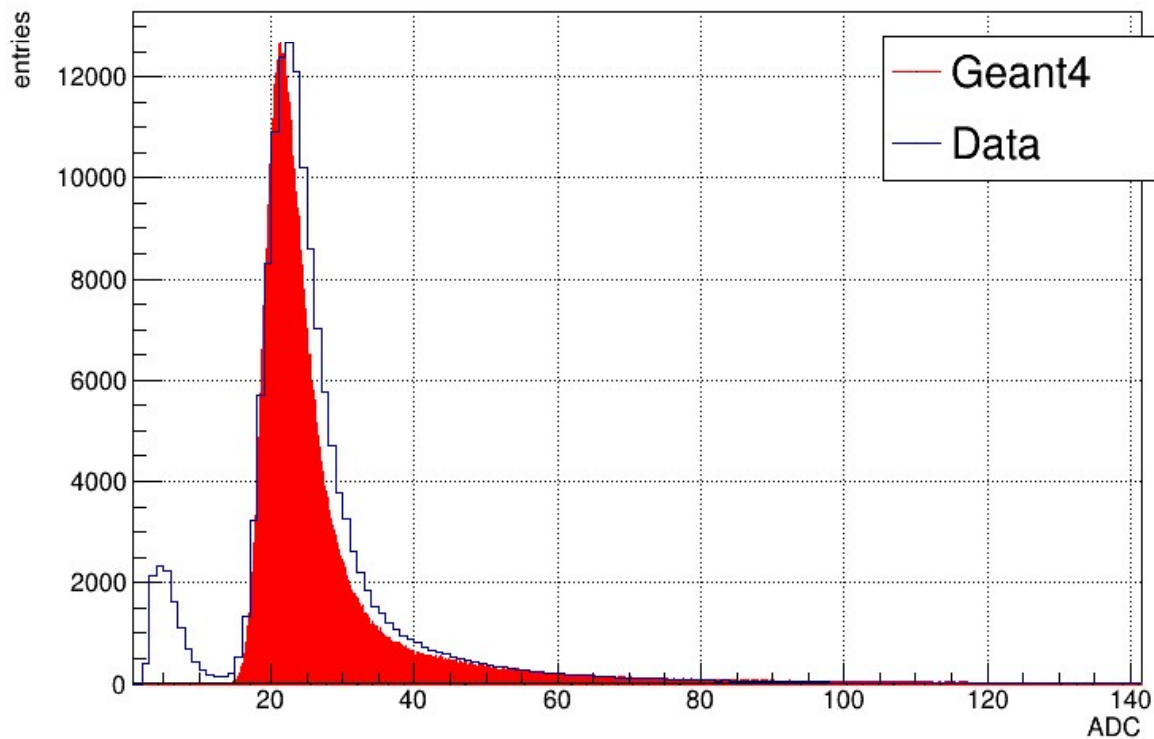
# 2022 TestBeam: MeV to ADC



### Data from run4436

- Beam on pads 49, 51, 59, 61
- **MPV =  $20.79 \pm 1.07$  [ADC]**

- **1 MeV = 228.79 ADC**

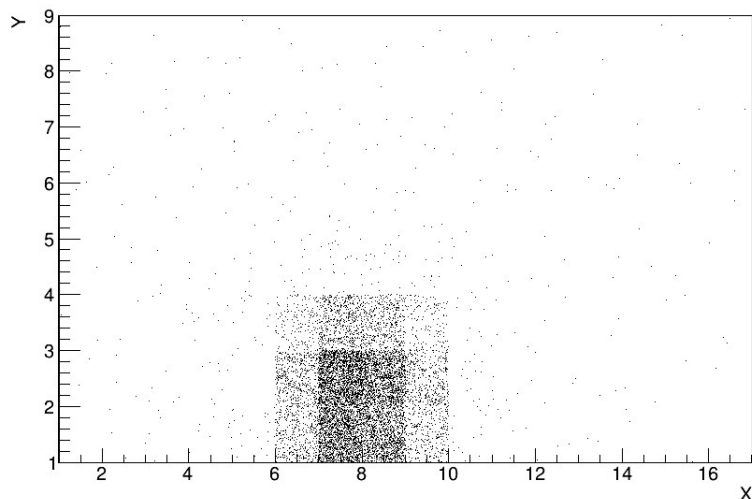


## ■ Si sensor – C74

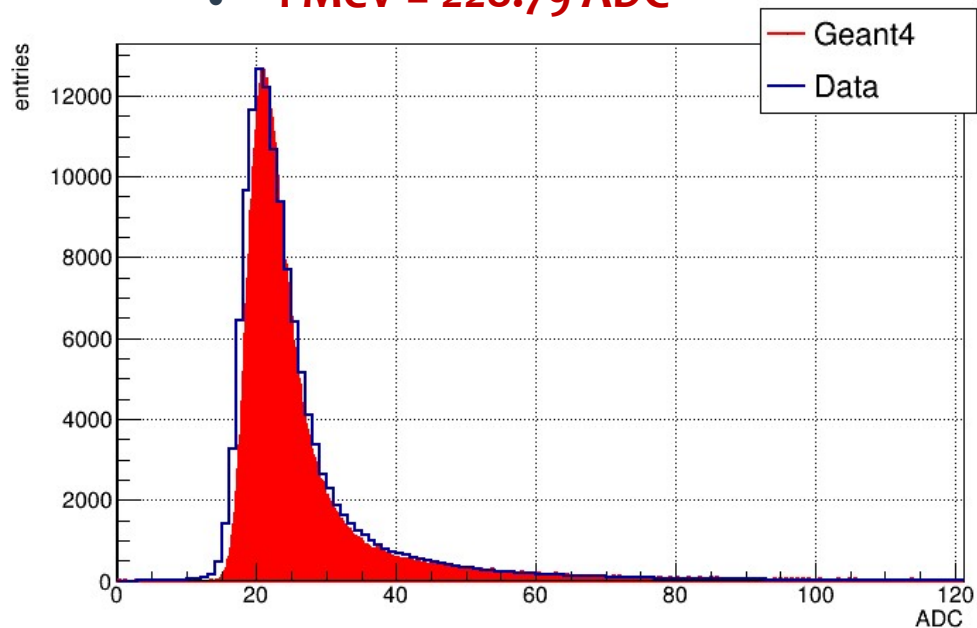
# TB 2022: Simulations vs Data

Data from run4545

Integrated Hit Map

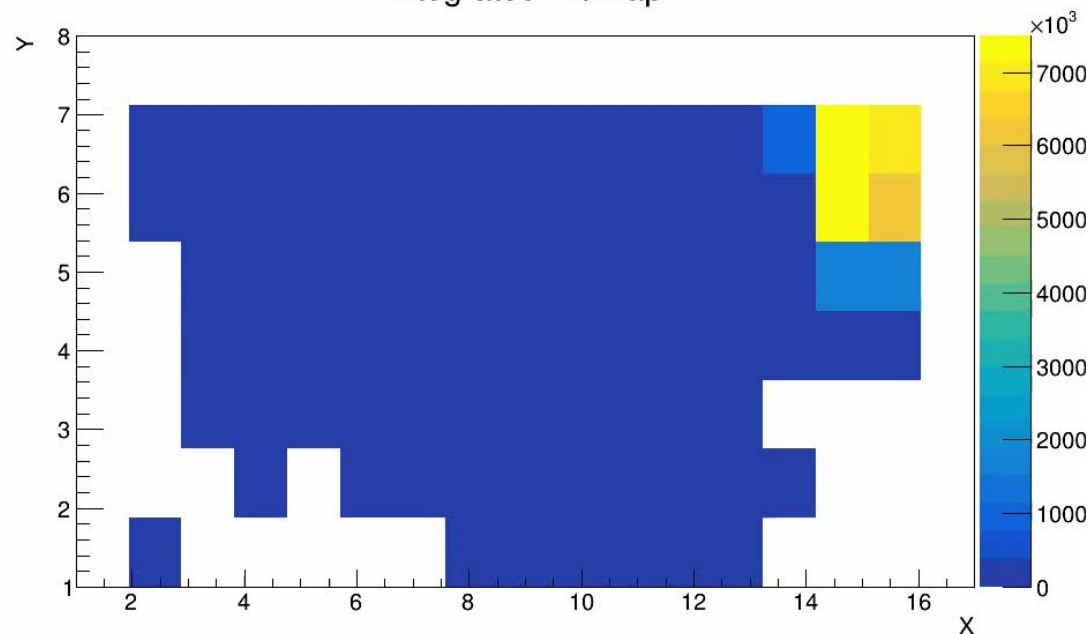


• 1 MeV = 228.79 ADC



Hitmap of the  
merged file of C74  
sensor - file from  
run4538 to run4551

Integrated Hit Map





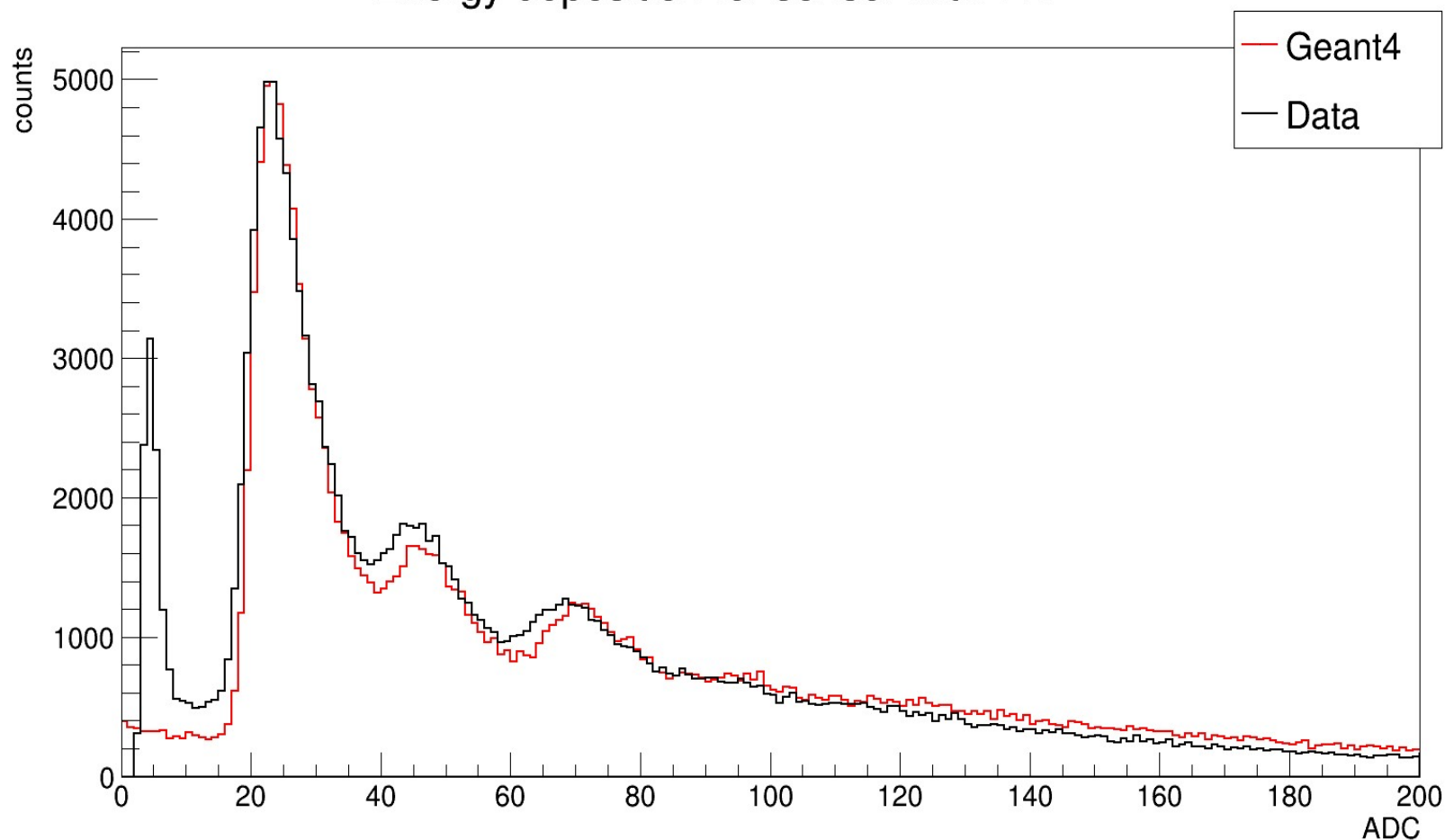
## ■ Si sensor – C74 & W

# TB 2022: Simulations vs Data

- 1 MeV = 228.79 ADC

Geant4: FTFP\_BERT\_EMZ

Energy deposition for sensor with 1W



run4749 – C74  
sensor with 1  
tungsten plate in  
front

## ■ Si sensor – C74 & W

# TB 2022: Simulations vs Data

case scenario: Si sensor with W in front

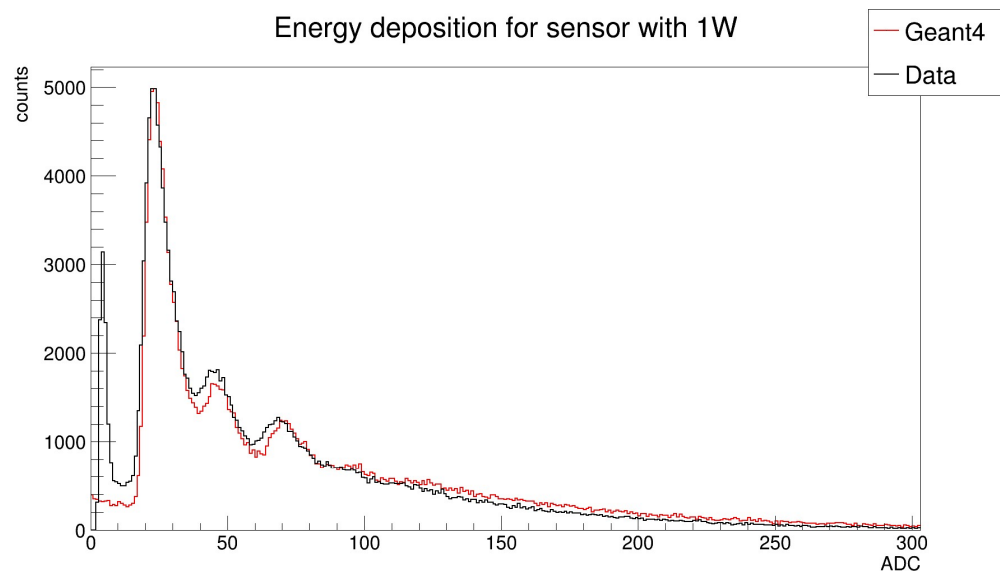
- **1 MeV = 228.79 ADC**

run4749 – 1W

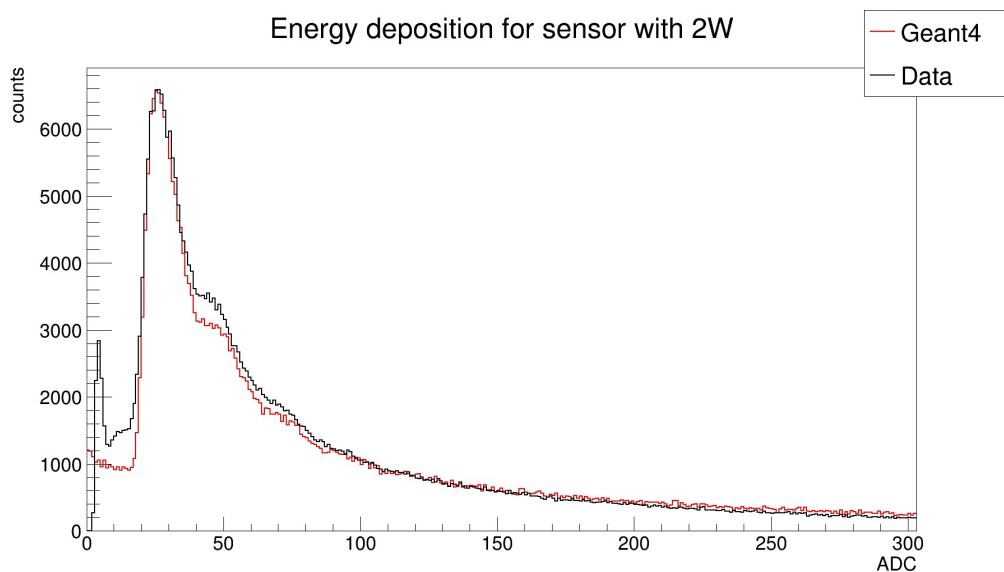
run4748 – 2W

run4747 – 3W

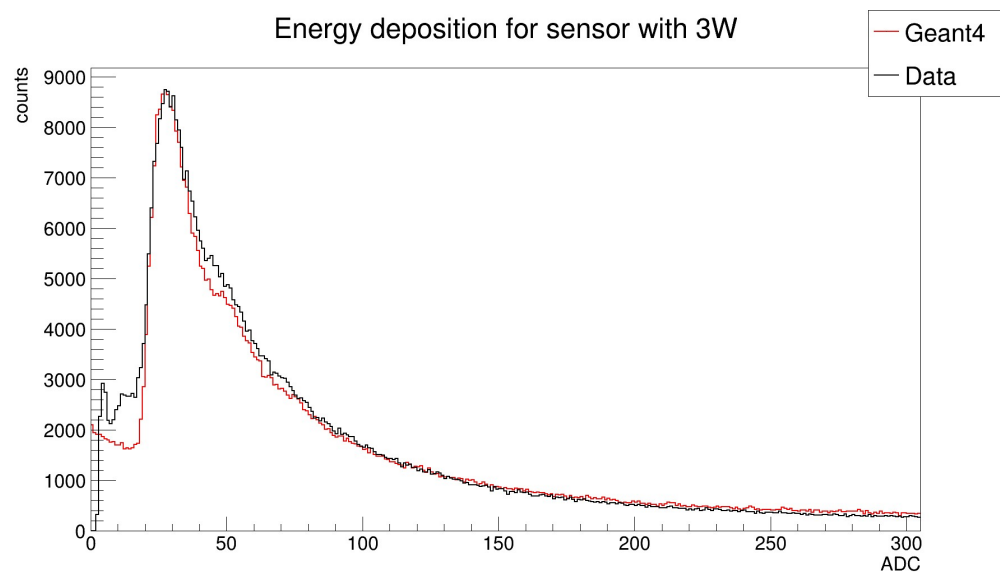
Energy deposition for sensor with 1W



Energy deposition for sensor with 2W



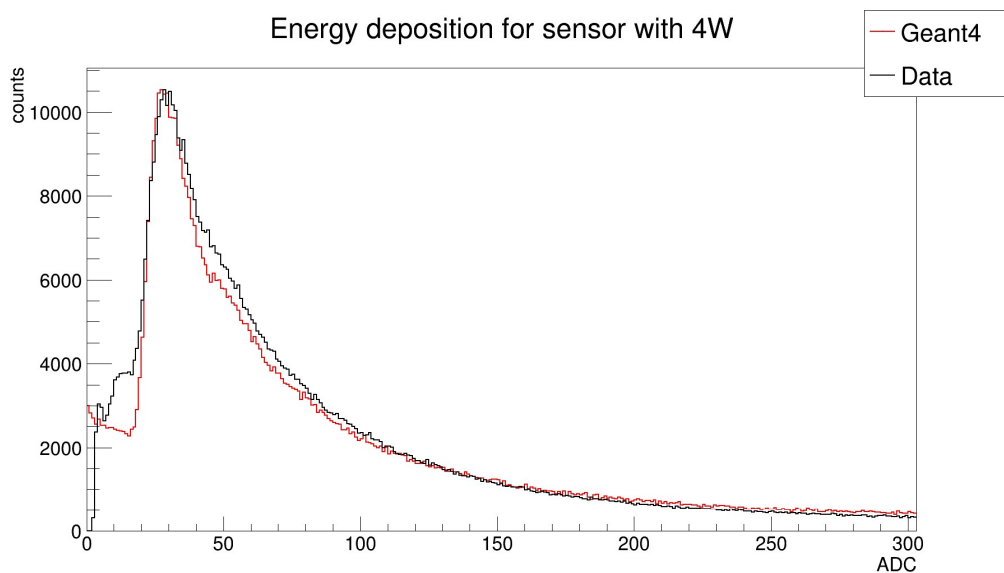
Energy deposition for sensor with 3W



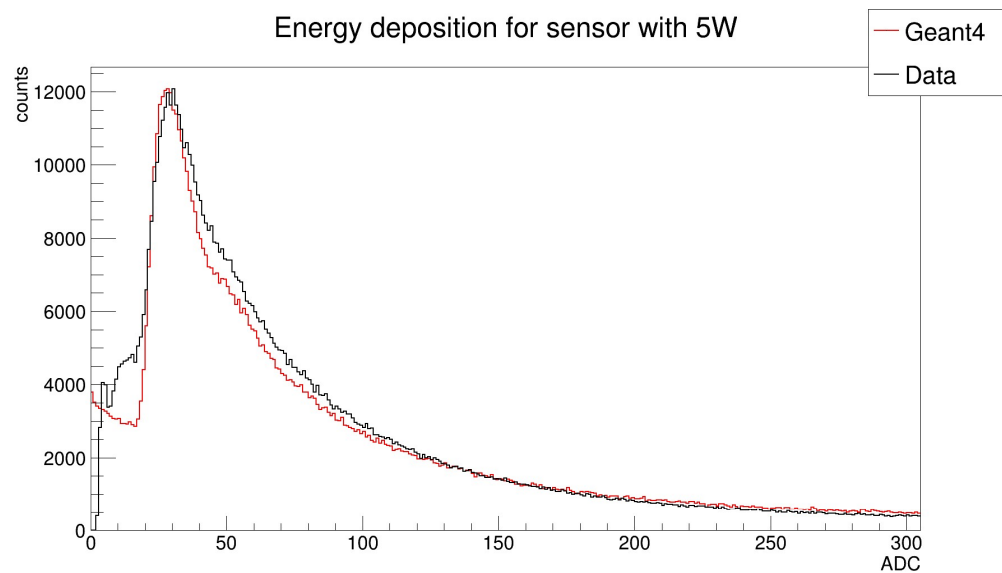
## ■ Si sensor – C74 & W

# TB 2022: Simulations vs Data

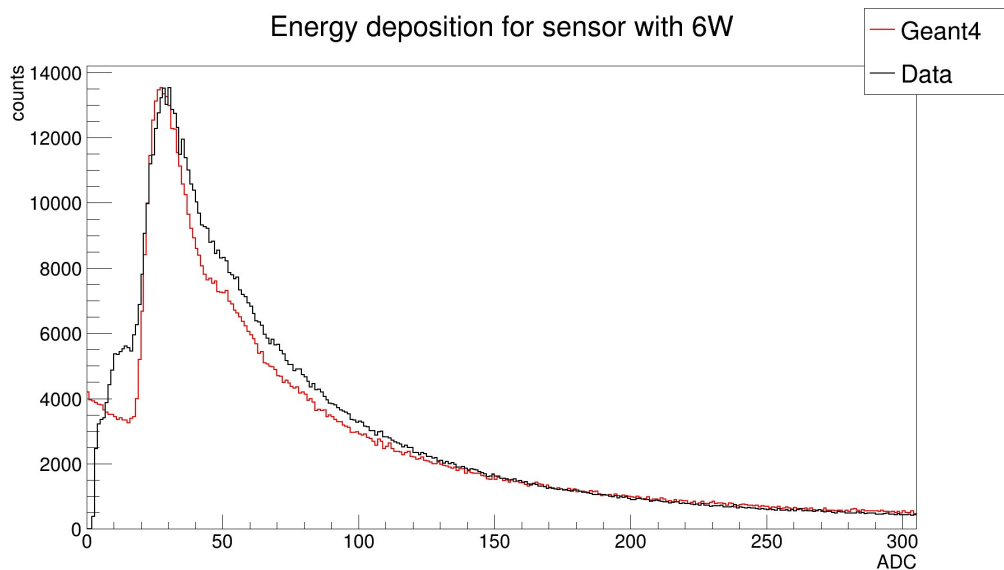
Energy deposition for sensor with 4W



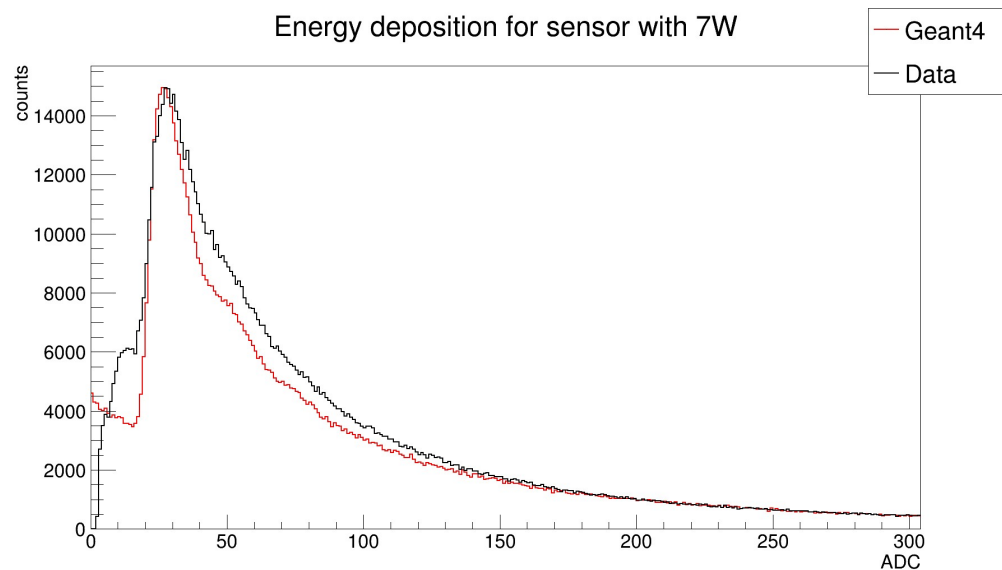
Energy deposition for sensor with 5W



Energy deposition for sensor with 6W



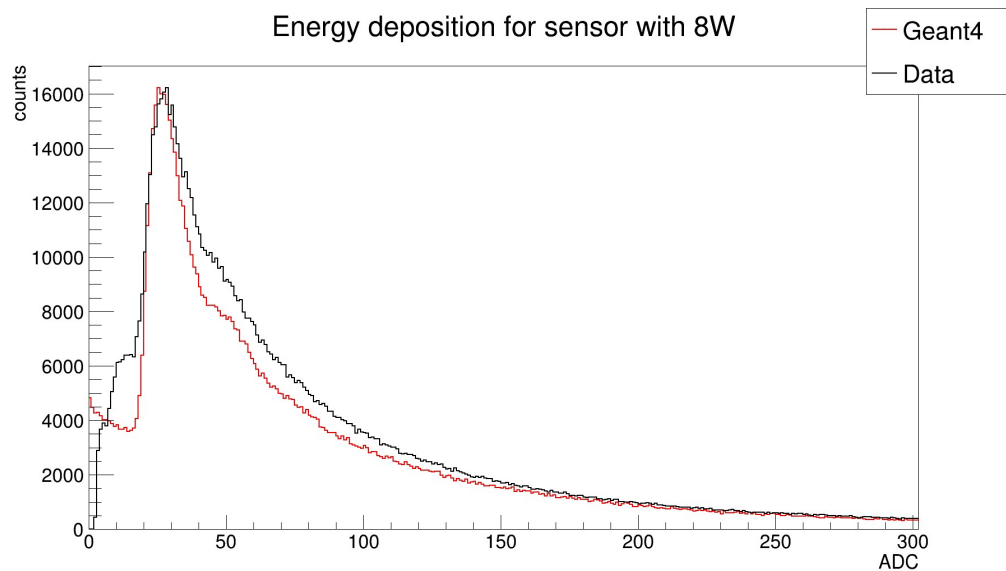
Energy deposition for sensor with 7W



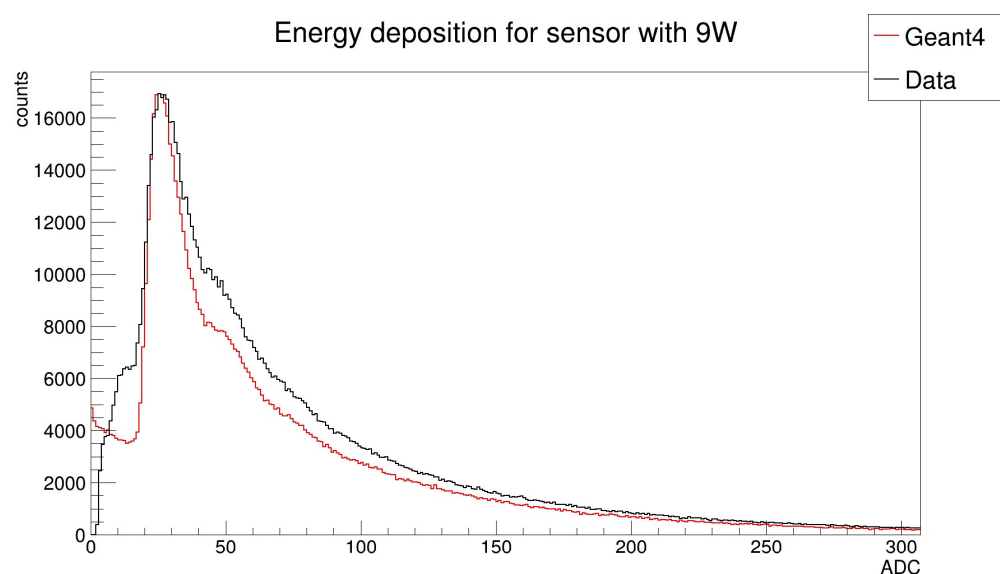
## ■ Si sensor – C74 & W

# TB 2022: Simulations vs Data

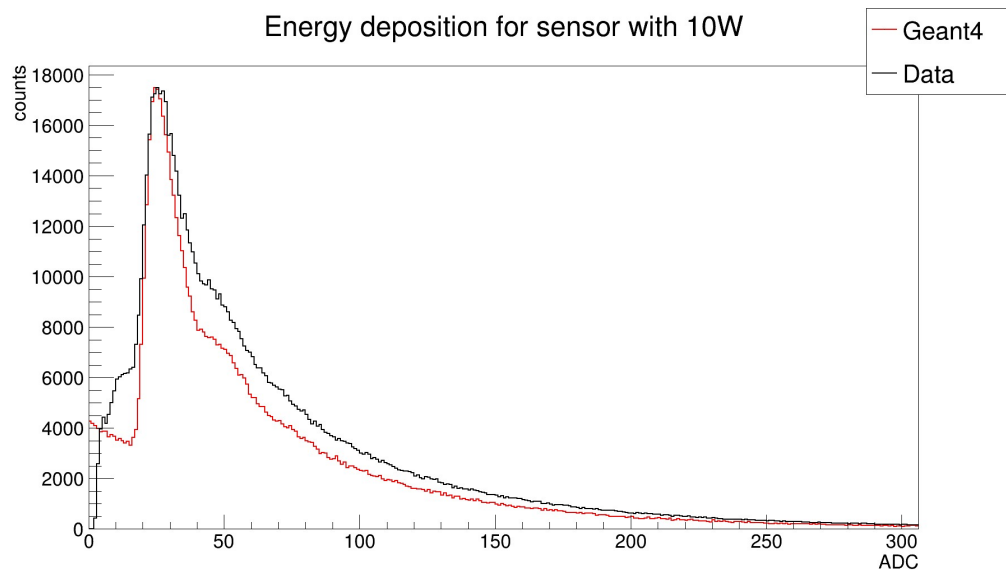
Energy deposition for sensor with 8W



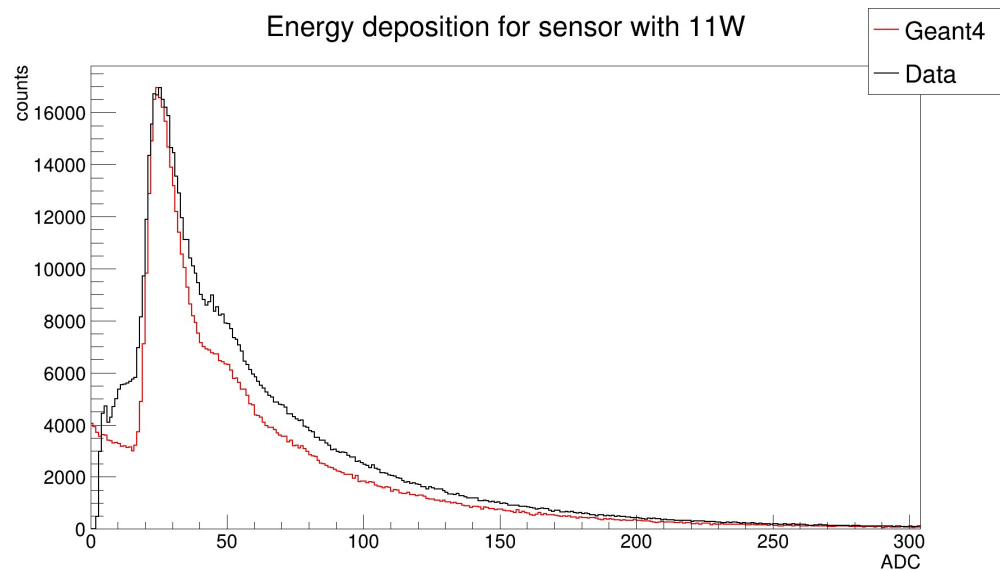
Energy deposition for sensor with 9W



Energy deposition for sensor with 10W



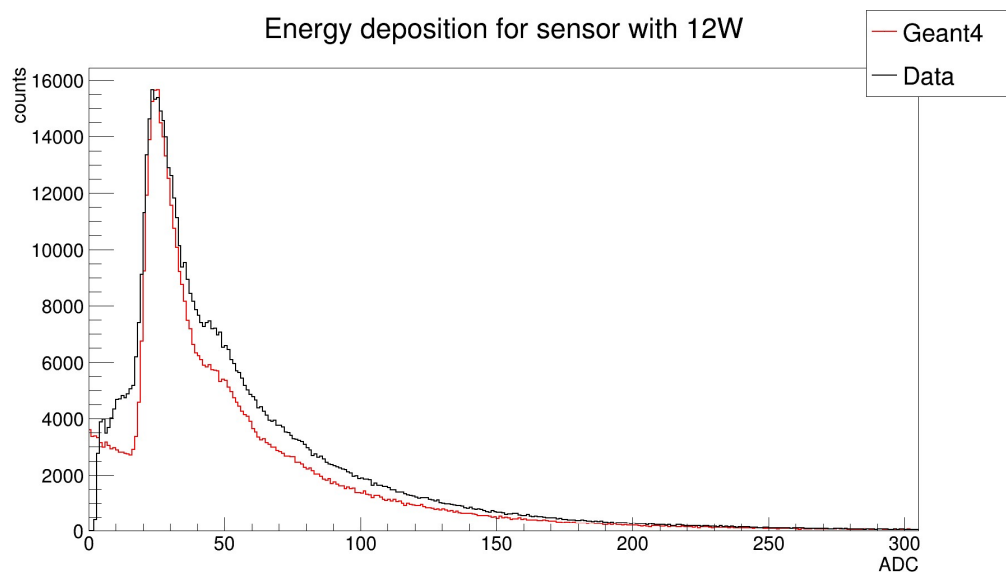
Energy deposition for sensor with 11W



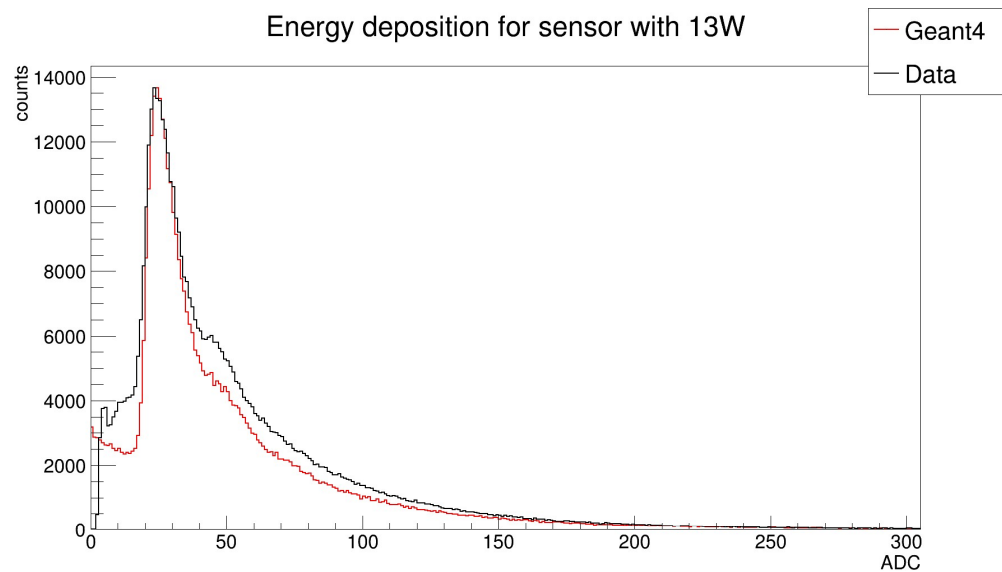
## ■ Si sensor – C74 & W

# TB 2022: Simulations vs Data

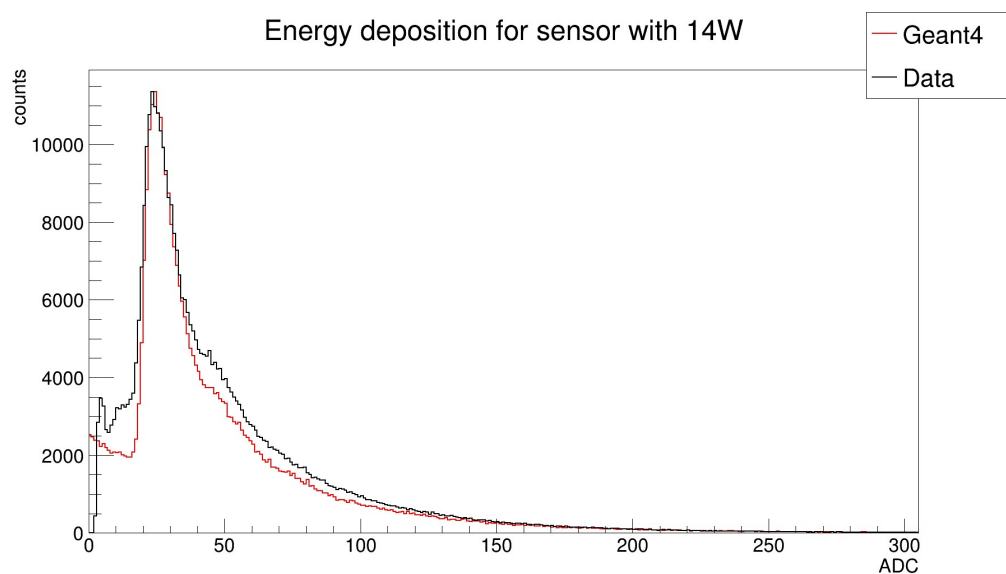
Energy deposition for sensor with 12W



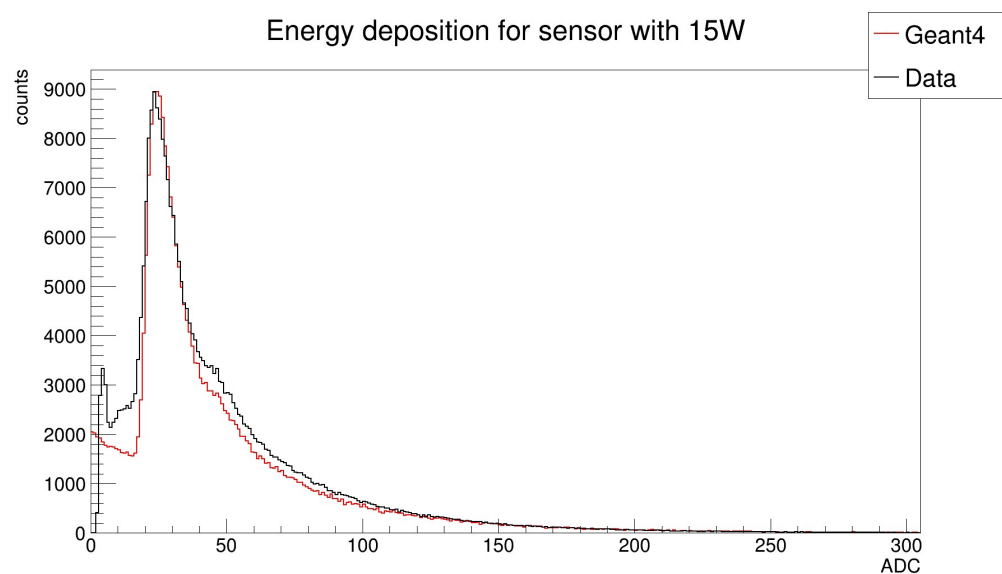
Energy deposition for sensor with 13W



Energy deposition for sensor with 14W



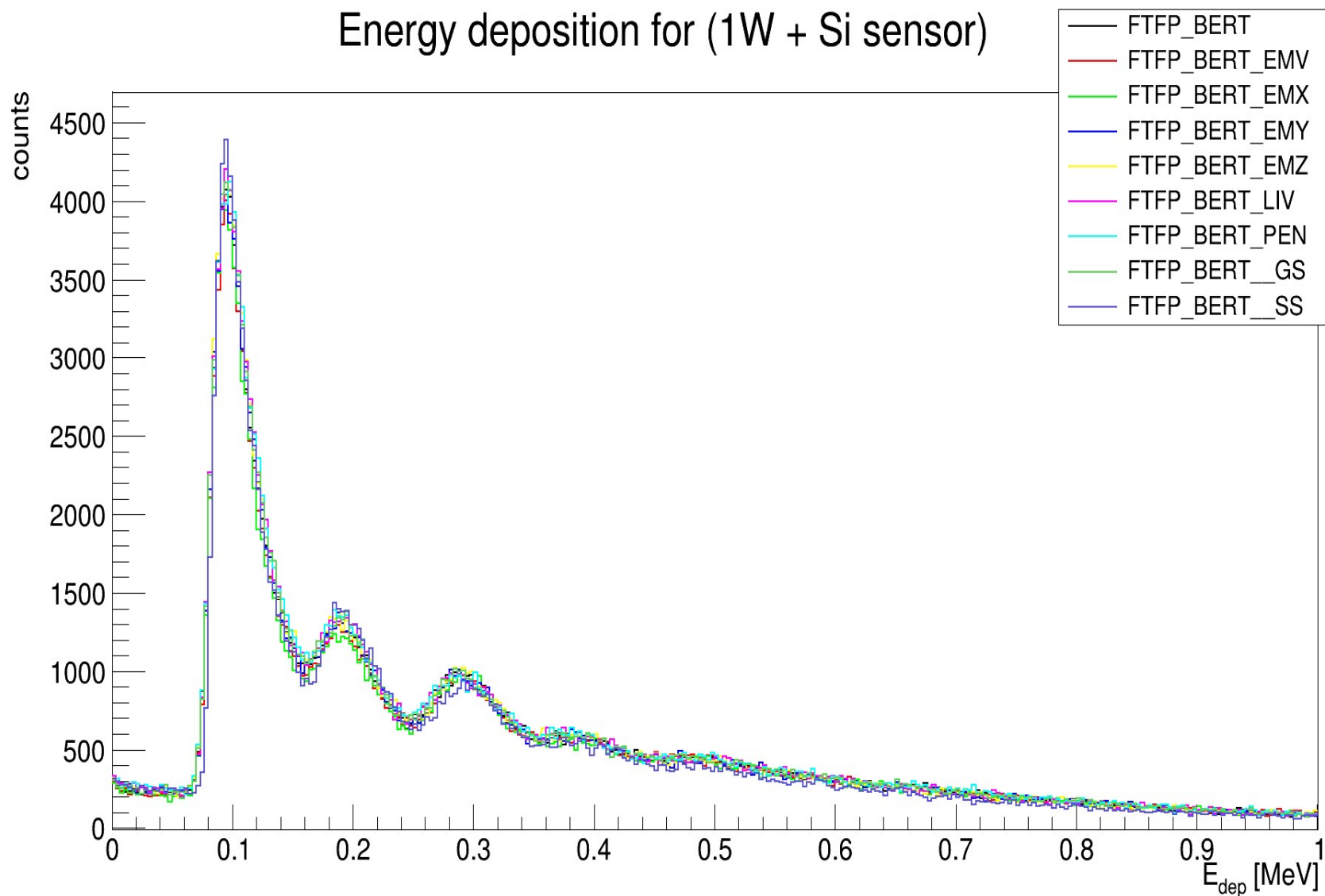
Energy deposition for sensor with 15W



## ■ Si sensor – C74 & W

# TB 2022: Geant4 Physics Lists

Energy deposition for (1W + Si sensor)



- FTF\_BIC
- FTFP\_BERT
- FTFP\_BERT\_HP
- FTFP\_BERT\_TRV
- FTFP\_BERT\_ATL
- FTFP\_INCLXX
- FTFP\_INCLXX\_HP
- FTFP\_QGSP\_BERT
- LBE
- NuBeam
- QGSP\_BERT
- QGSP\_BERT\_HP
- QGSP\_BIC
- QGSP\_BIC\_HP
- QGSP\_BIC\_AllHP
- QGSP\_FTFP\_BERT
- QGSP\_INCLXX
- QGSP\_INCLXX\_HP
- QGS\_BIC
- Shielding
- ShieldingLEND

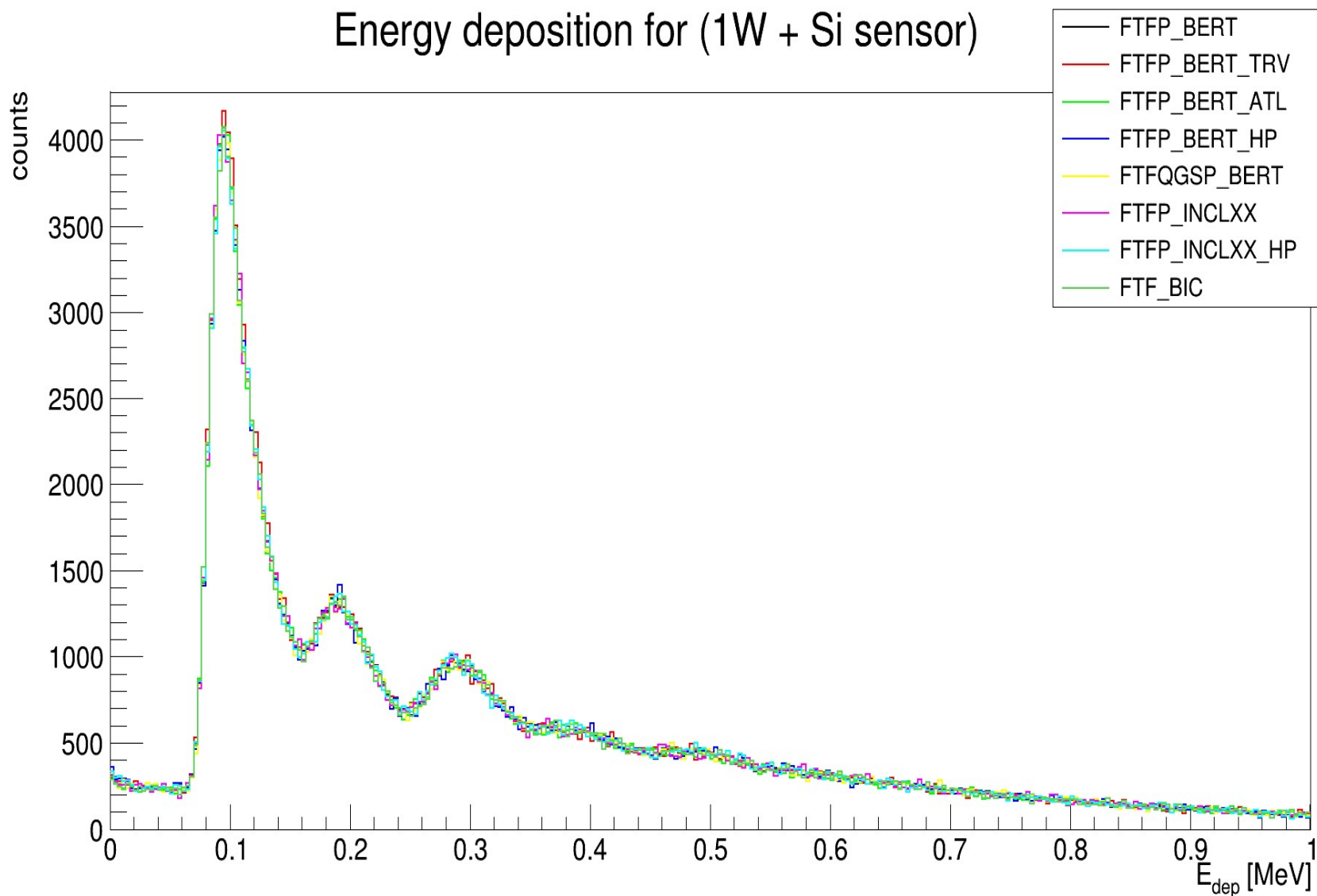


## ■ Si sensor – C74 & W

# TB 2022: Geant4 Physics Lists

- FTF\_BIC
- FTFP\_BERT
- FTFP\_BERT\_HP
- FTFP\_BERT\_TRV
- FTFP\_BERT\_ATL
- FTFP\_INCLXX
- FTFP\_INCLXX\_HP
- FTFP\_QGSP\_BERT
- LBE
- NuBeam
- QGSP\_BERT
- QGSP\_BERT\_HP
- QGSP\_BIC
- QGSP\_BIC\_HP
- QGSP\_BIC\_AllHP
- QGSP\_FTFP\_BERT
- QGSP\_INCLXX
- QGSP\_INCLXX\_HP
- QGS\_BIC
- Shielding
- ShieldingLEND

Energy deposition for (1W + Si sensor)

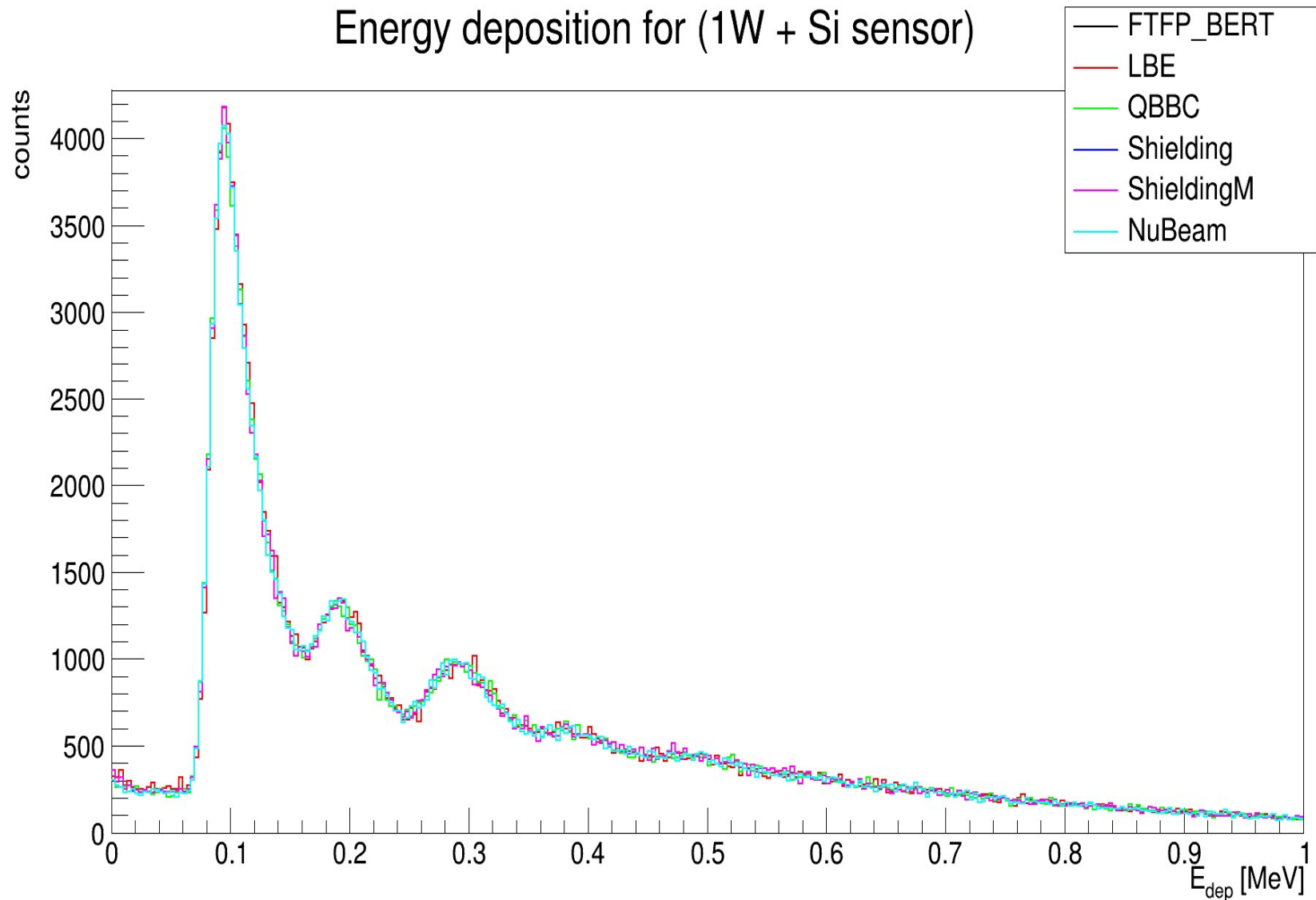


## ■ Si sensor – C74 & W

# TB 2022: Geant4 Physics Lists

- FTF\_BIC
- FTFP\_BERT
- FTFP\_BERT\_HP
- FTFP\_BERT\_TRV
- FTFP\_BERT\_ATL
- FTFP\_INCLXX
- FTFP\_INCLXX\_HP
- FTFP\_QGSP\_BERT
- LBE
- NuBeam
- QGSP\_BERT
- QGSP\_BERT\_HP
- QGSP\_BIC
- QGSP\_BIC\_HP
- QGSP\_BIC\_AllHP
- QGSP\_FTFP\_BERT
- QGSP\_INCLXX
- QGSP\_INCLXX\_HP
- QGS\_BIC
- Shielding
- ShieldingLEND

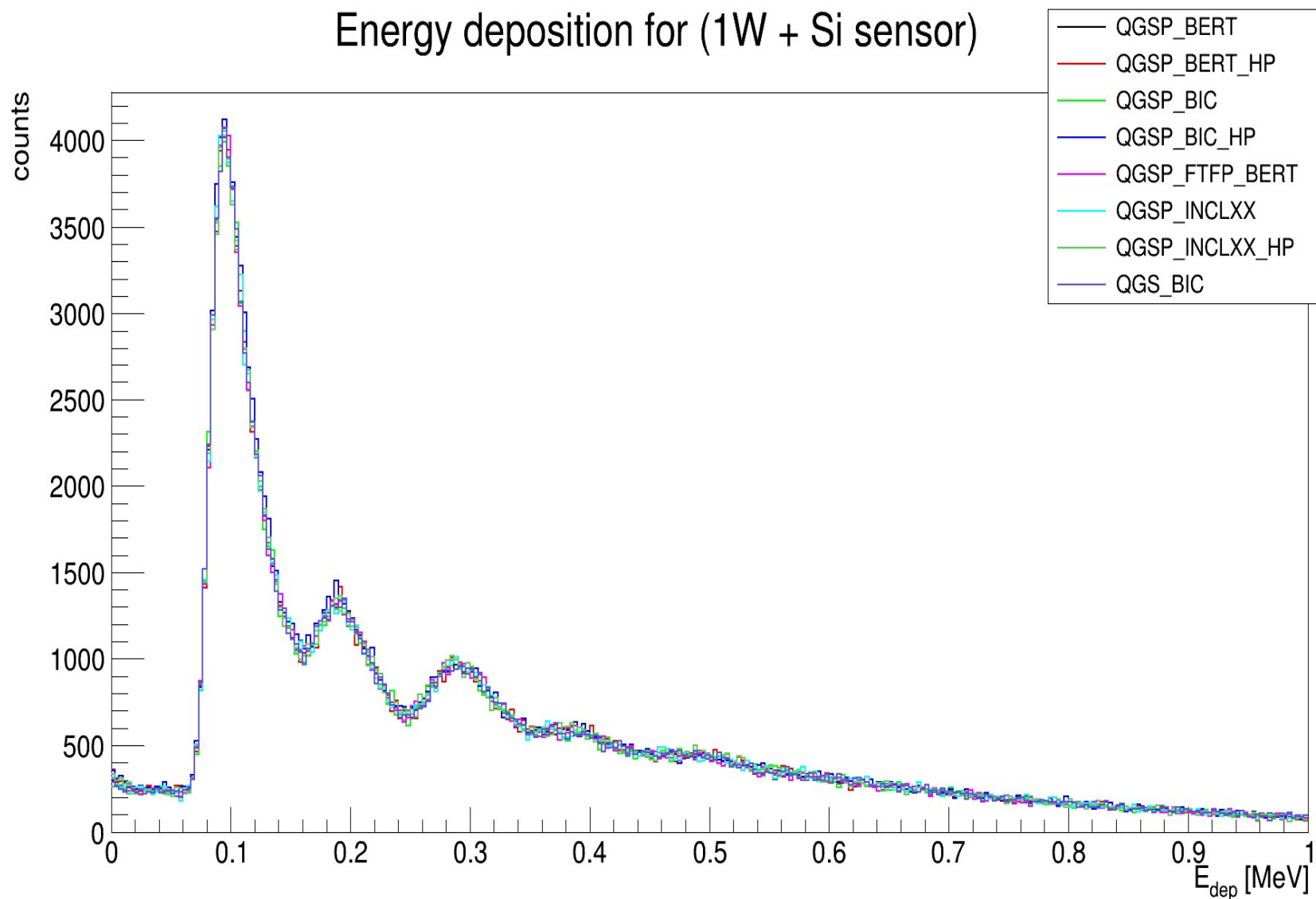
Energy deposition for (1W + Si sensor)



## ■ Si sensor – C74 & W

# TB 2022: Geant4 Physics Lists

Energy deposition for (1W + Si sensor)



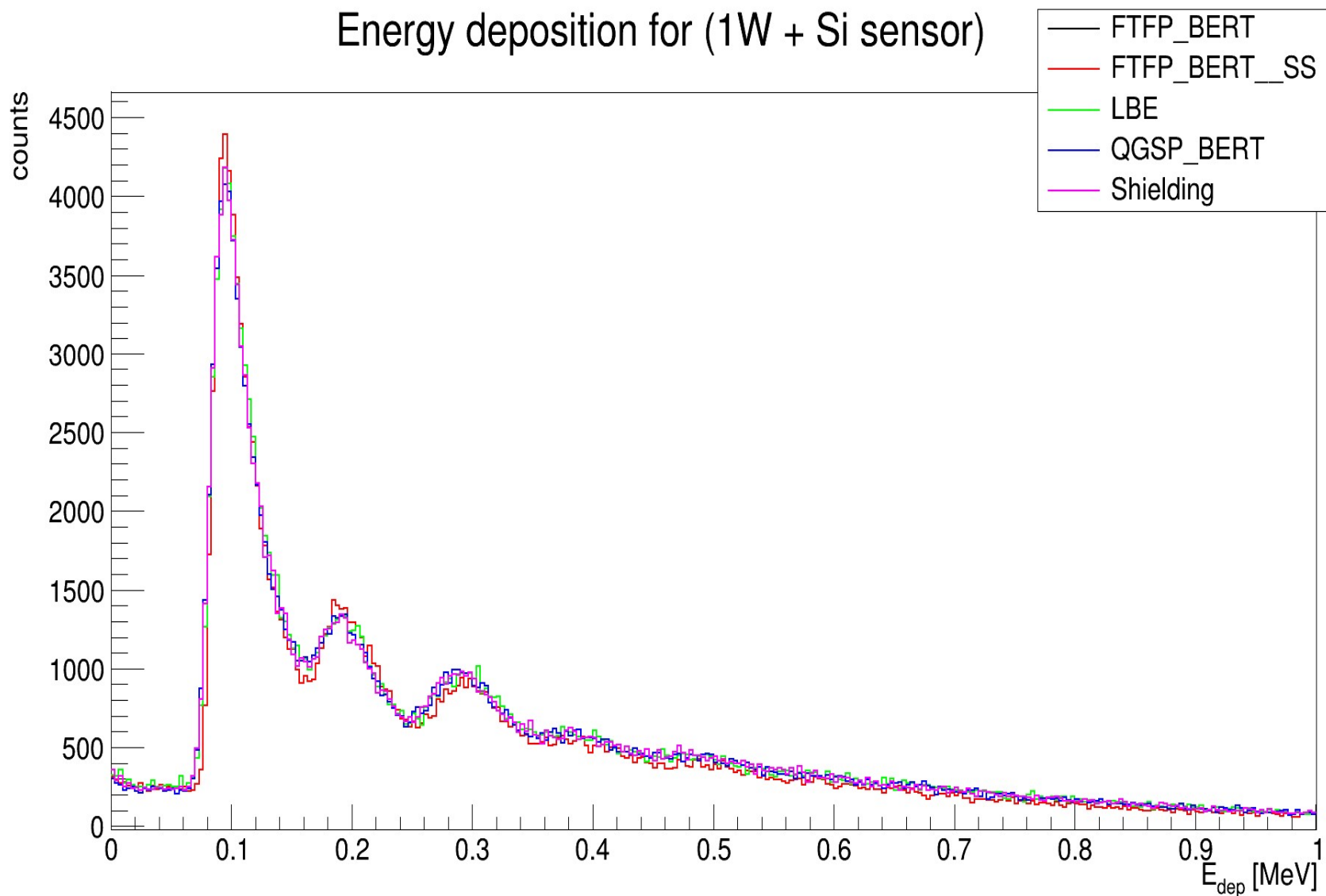
- FTF\_BIC
- FTFP\_BERT
- FTFP\_BERT\_HP
- FTFP\_BERT\_TRV
- FTFP\_BERT\_ATL
- FTFP\_INCLXX
- FTFP\_INCLXX\_HP
- FTFP\_QGSP\_BERT
- LBE
- NuBeam
- QGSP\_BERT
- QGSP\_BERT\_HP
- QGSP\_BIC
- QGSP\_BIC\_HP
- QGSP\_BIC\_AllHP
- QGSP\_FTFP\_BERT
- QGSP\_INCLXX
- QGSP\_INCLXX\_HP
- QGS\_BIC
- Shielding
- ShieldingLEND

## ■ Si sensor – C74 & W

# TB 2022: Geant4 Physics Lists

- FTF\_BIC
- FTFP\_BERT
- FTFP\_BERT\_HP
- FTFP\_BERT\_TRV
- FTFP\_BERT\_ATL
- FTFP\_INCLXX
- FTFP\_INCLXX\_HP
- FTFP\_QGSP\_BERT
- LBE
- NuBeam
- QGSP\_BERT
- QGSP\_BERT\_HP
- QGSP\_BIC
- QGSP\_BIC\_HP
- QGSP\_BIC\_AllHP
- QGSP\_FTFP\_BERT
- QGSP\_INCLXX
- QGSP\_INCLXX\_HP
- QGS\_BIC
- Shielding
- ShieldingLEND

Energy deposition for (1W + Si sensor)

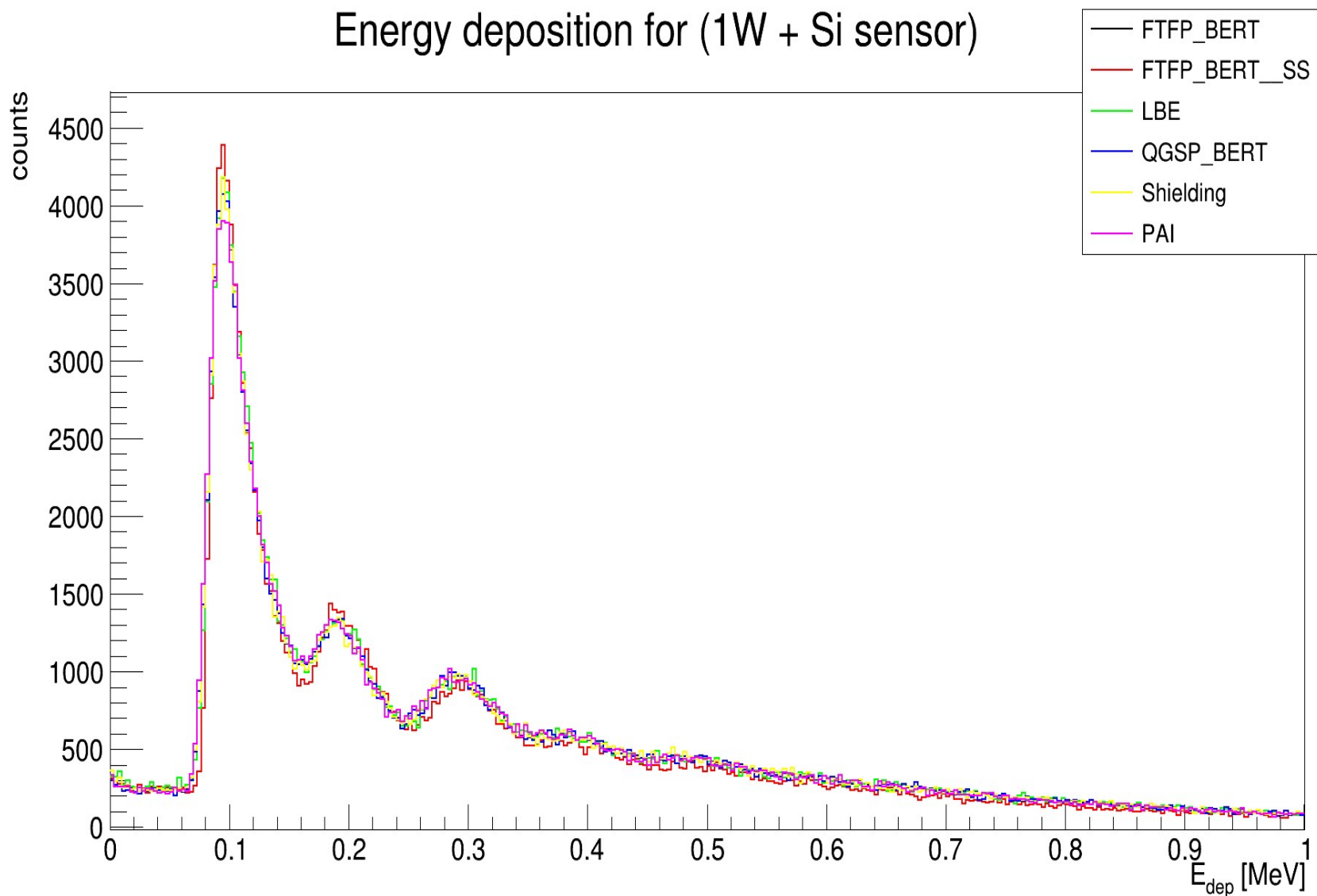


## ■ Si sensor – C74 & W

# TB 2022: Geant4 Physics Lists

- FTF\_BIC
- FTFP\_BERT
- FTFP\_BERT\_HP
- FTFP\_BERT\_TRV
- FTFP\_BERT\_ATL
- FTFP\_INCLXX
- FTFP\_INCLXX\_HP
- FTFP\_QGSP\_BERT
- LBE
- NuBeam
- QGSP\_BERT
- QGSP\_BERT\_HP
- QGSP\_BIC
- QGSP\_BIC\_HP
- QGSP\_BIC\_AllHP
- QGSP\_FTFP\_BERT
- QGSP\_INCLXX
- QGSP\_INCLXX\_HP
- QGS\_BIC
- Shielding
- ShieldingLEND

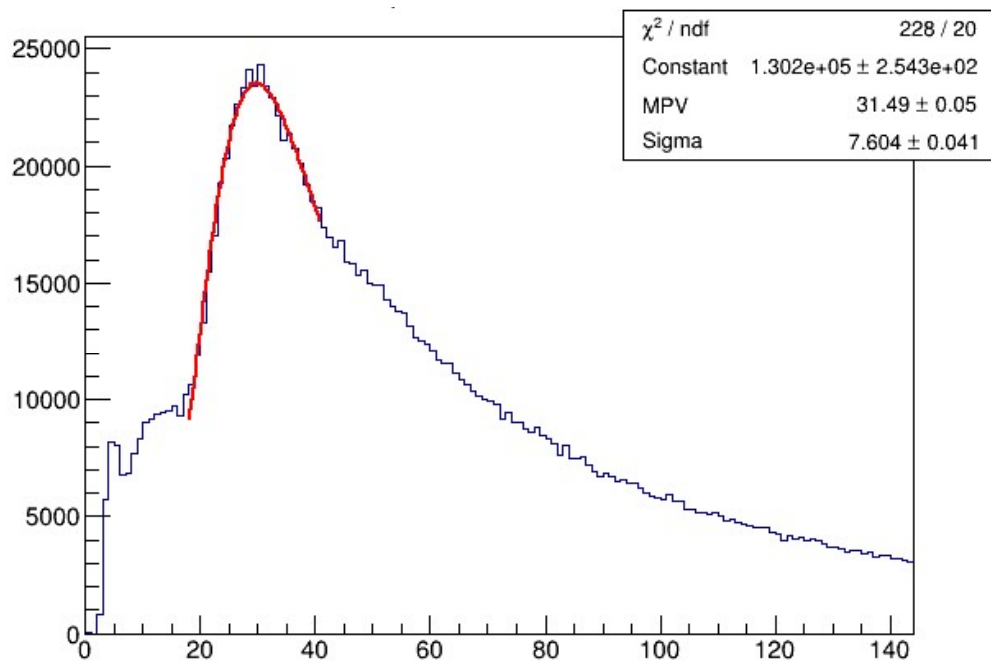
Energy deposition for (1W + Si sensor)



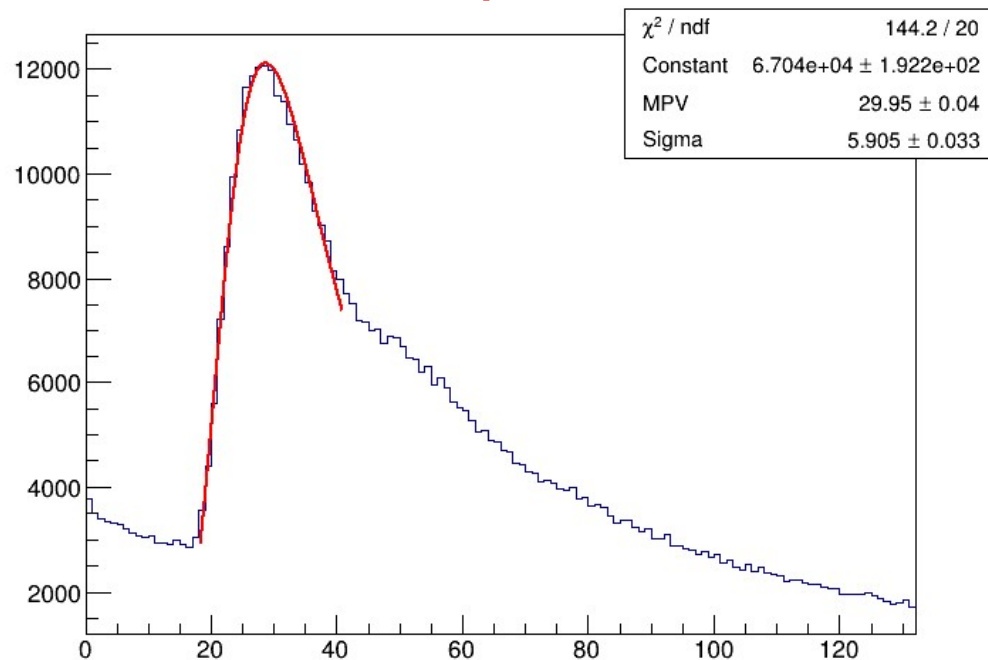
## ■ Si sensor – C74 & W

# TB 2022: Simulations vs Data

### • Data



### • Geant4

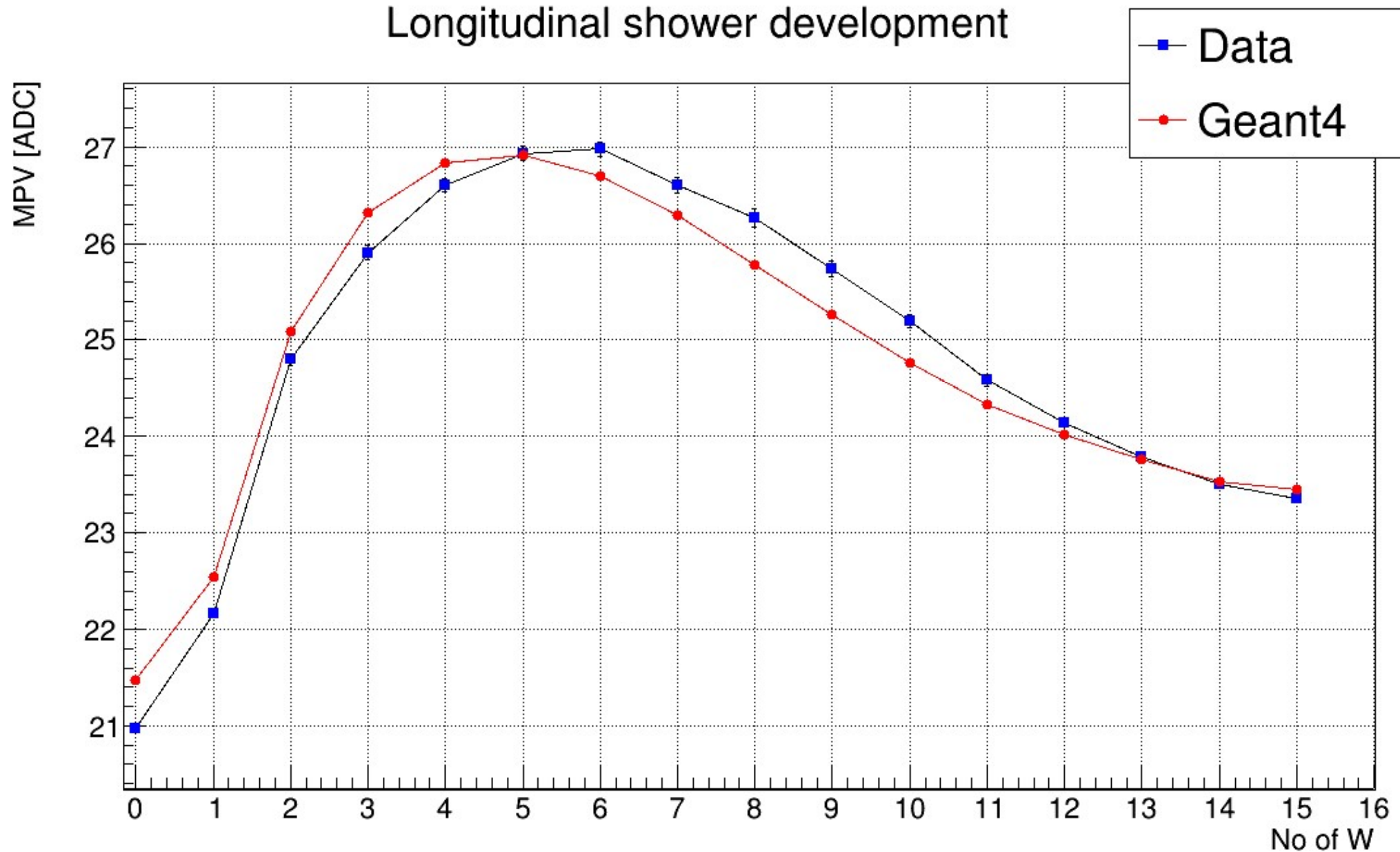




■ Si sensor – C74 & W

## TB 2022: Geant4 vs Data

Longitudinal shower development



# TB 2022 Simulations - update

- Energy deposition on (W + C74 sensor)
  - placed all tungsten plates in the same position as in test-beam taking into account that the plates were removed one by one starting with the one placed further of the sensor - **no noticeable influence!**
  - checked the composition of each tungsten plate and implemented in Geant4 simulations – **no noticeable influence!**
  - modified the beam profile using a Gaussian shape of the energy distribution for the incoming electrons - **no noticeable influence!**
  - modify the physics list to include / exclude some process – *work in progress.*

Stack configuration				
V beam V				
Slot 1	Plane "1"	tungsten	3,505	abs95
Slot 2	Plane "3"	tungsten	3,520	abs95
Slot 3	A5	tungsten	3,528	abs95
Slot 4	A2	tungsten	3,550	abs95
Slot 5	Plane "4"	tungsten	3,475	abs95
Slot 6	B12	tungsten	3,550	abs95
Slot 7	A8	tungsten	3,558	abs95
Slot 8	B23	tungsten	3,543	abs95
Slot 9	B21	tungsten		
Slot 10	1 (A3)	tungsten		
Slot 11	B19	tungsten		
Slot 12	B14	tungsten		
Slot 13	7 (MGS2)	tungsten	3,521	abs93
Slot 14	10 (MGS5)	tungsten	3,645	abs93
Slot 15	11 (MGS6)	tungsten	3,470	abs93
Slot 16	---	gap		
Slot 17	Calice 74	sensor		
Slots 18--end	---	empty		

```

/gps/particle e-

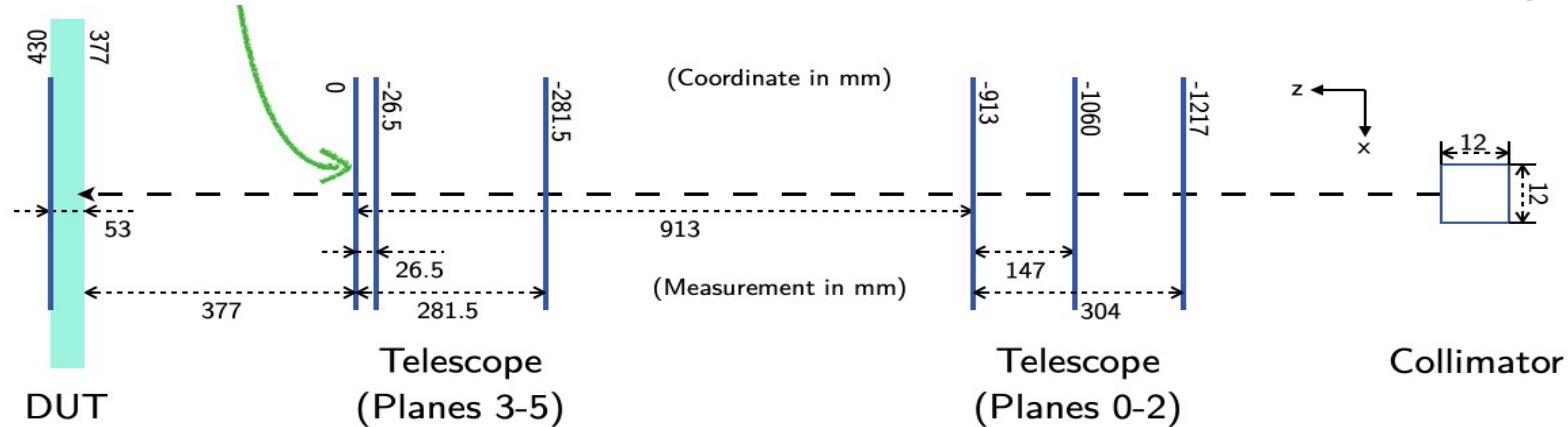
/gps/pos/type Beam
/gps/pos/shape Rectangle
/gps/pos/halfx 0.6 cm
/gps/pos/halfy 0.6 cm
/gps/pos/centre 0. 0. -200. cm
/gps/direction 0 0 1

/gps/ene/type Gauss
/gps/ene/mono 5000 MeV
/gps/ene/sigma 50. MeV

/run/beamOn 500000
  
```

# TB 2022: Configurations

- Geometry implementation in Geant4 - 10 experimental setups - 38 different configurations



- Ga-As sensor – Anton1

1 exp. setups without any W plates

Energies: 5 GeV c

- Ga-As sensor – Yan1

1 exp. setup without W plates

Energies: 5 GeV

1 exp. setup with 5 W plates

Energies: 1 GeV, 3 GeV, 5 GeV

1 exp. setups with decreased no of plates 15 -> 1 W

Energies: 5 GeV

- Ga-As sensor – BeamCal

1 exp. setups without any W plates

Energies: 5 GeV

- Si sensor – C72

1 exp. setups without any W plates

Energies: 5 GeV

- Si sensor – C74

1 exp. setups without any W plates

Energies: 5 GeV

1 exp. setup with 5 W plates

Energies: 1 GeV, 3 GeV, 5 GeV

1 exp. setups with decreased no of plates 15 -> 1 W

Energies: 5 GeV

- Si sensor – C72

1 exp. setups without any W plates

Energies: 5 GeV